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Low Energy Beam Transport Beam diagnostics

- * Introduction
- * Destructive methods
- * RGI - Spectroscopy
- * CCD - imaging
- * Tomography
- * Laser neutralisation
- * Examples



Motivation:

A detailed knowledge of the physical properties defining the beam transport like

- external field distribution
 - residual gas pressure
 - beam current
 - beam emittance
 - beam potential (space charge)

is
necessary for the

design,
optimisation
and
operation

of an

Low Energy Beam Transport section



Emittance & emittance measurement

The behavior of an ion beam consisting of n particles can be totally described in the $6n$ dimensional phase space

$$\Gamma_{6n}$$

Reduction : Transformation of density distribution

$$f_6 = f(x, y, z, p_x, p_y, p_z)$$

Reduction : transversal density distribution

$$f_4 = f(x, y, p_x, p_y)$$

Reduction : edge emittance, normalizing

$$\varepsilon_{n,x} = \beta\gamma \frac{F(x, x')}{\pi}$$

Redefinition : RMS from particle moments

$$\varepsilon_{n,rms} = \beta\gamma \sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx'^2 \rangle}$$



Emittance measurement :

“Simultaneous determination
of spatial and transversal impuls
distribution of an particle ensemble“

2 step process :
e.g.

1 step - definition of “place”

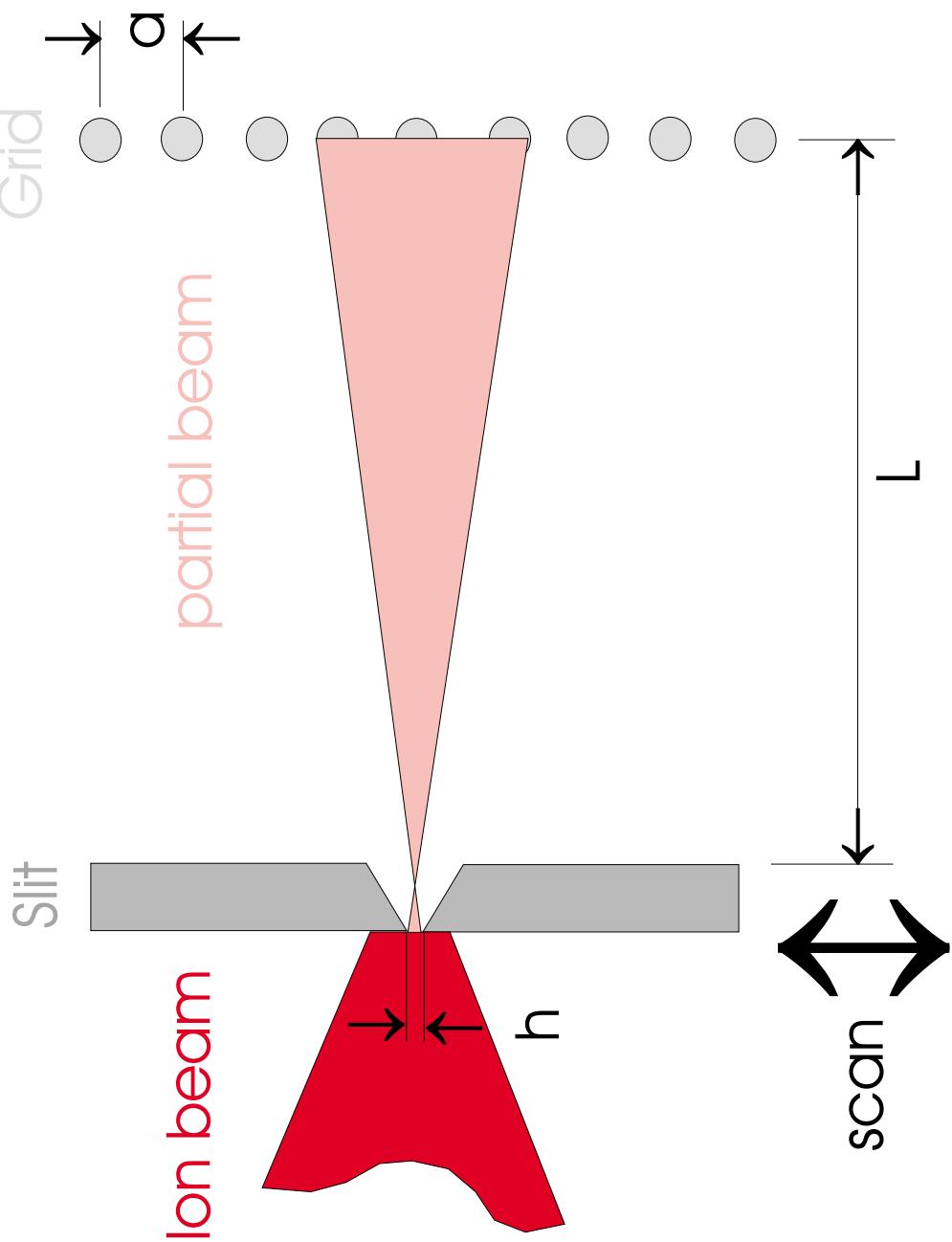
=> by extraction of subset of particle distribution

2. step - determination of “angle”

=> determination of particle distribution
after drift



Slit - Grid arrangement





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High resolution
Slit - Grid
emittance scanner
including 2 dimensional profile measurement





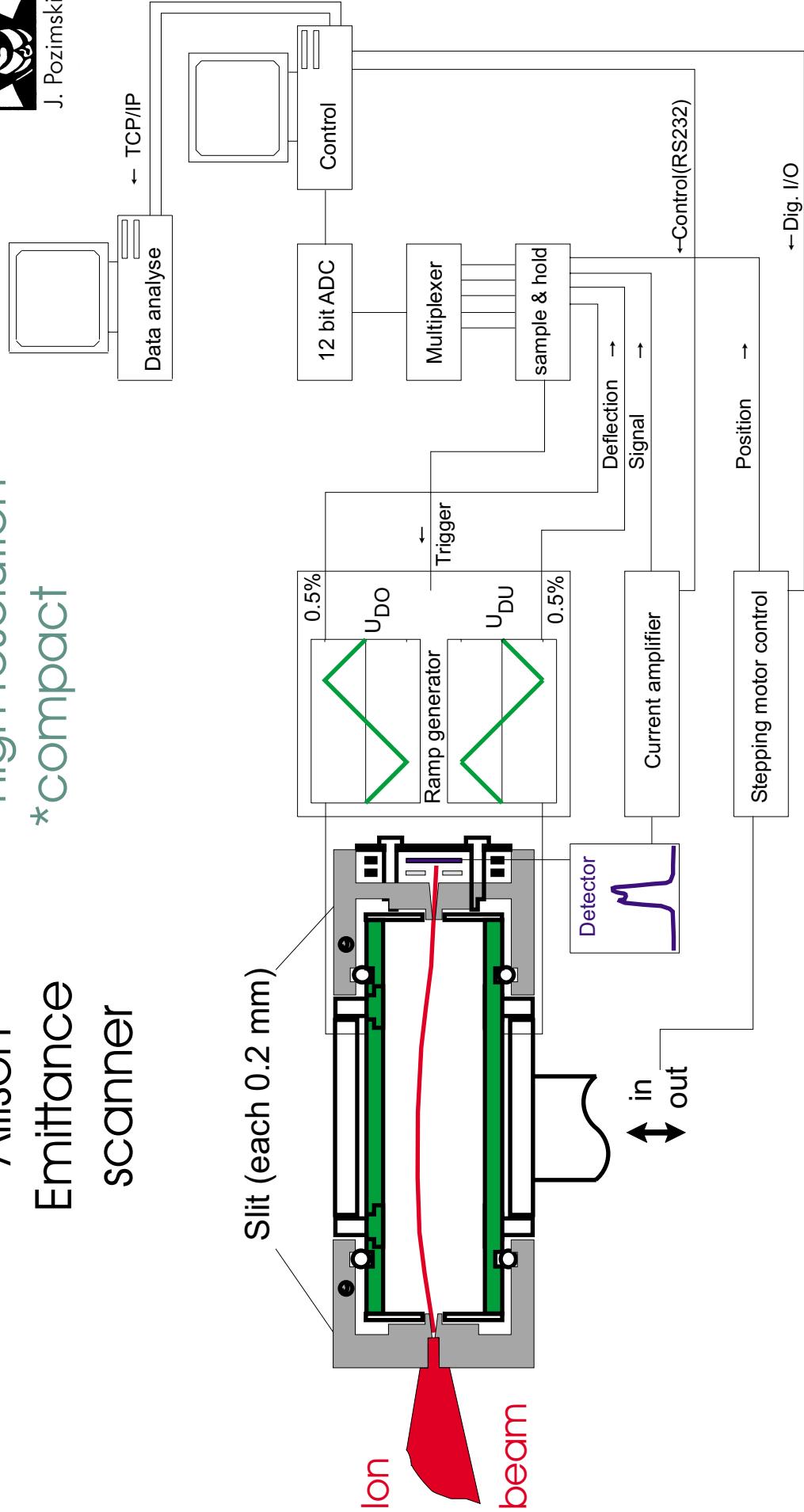
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Allison Emittance scanner

*high resolution
*compact

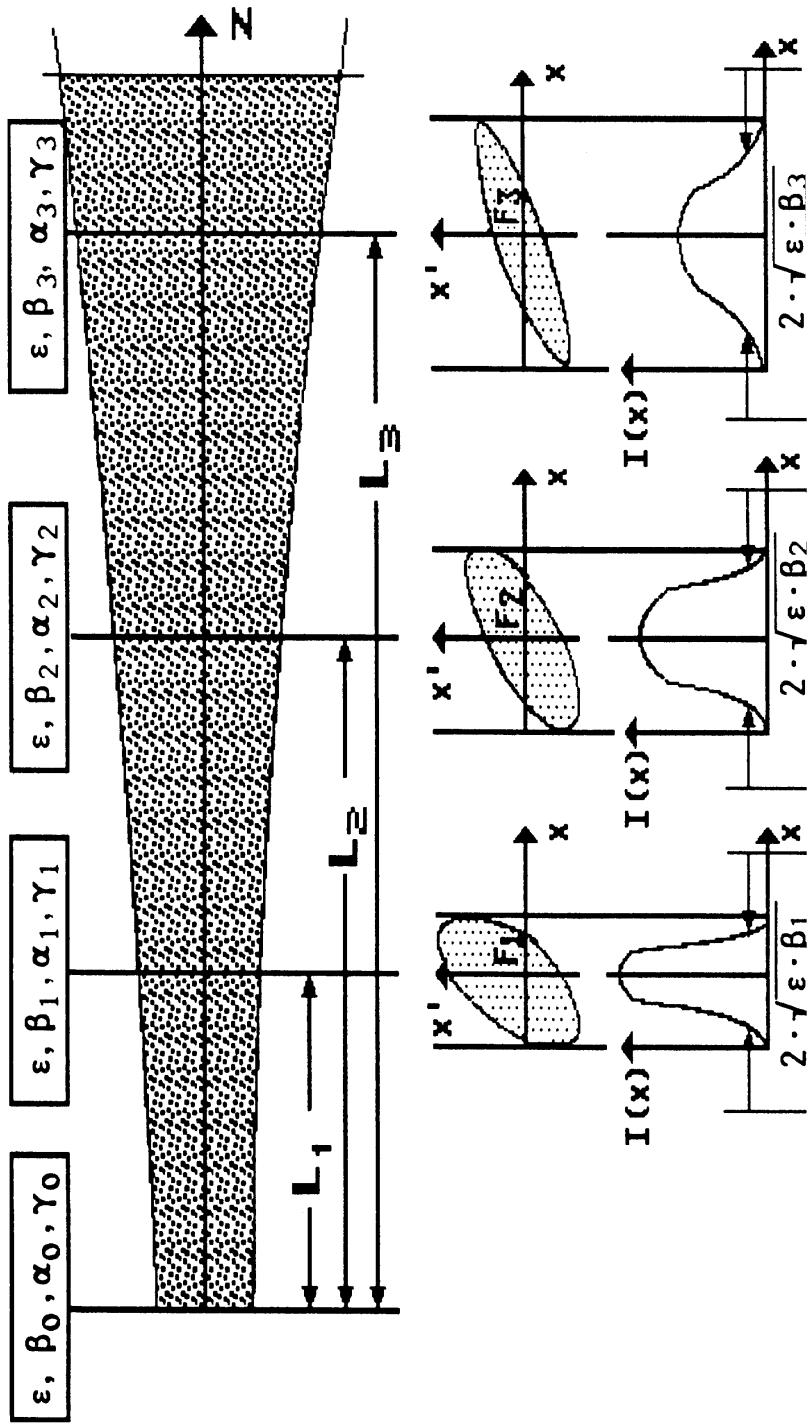
Slit (each 0.2 mm)

ion beam



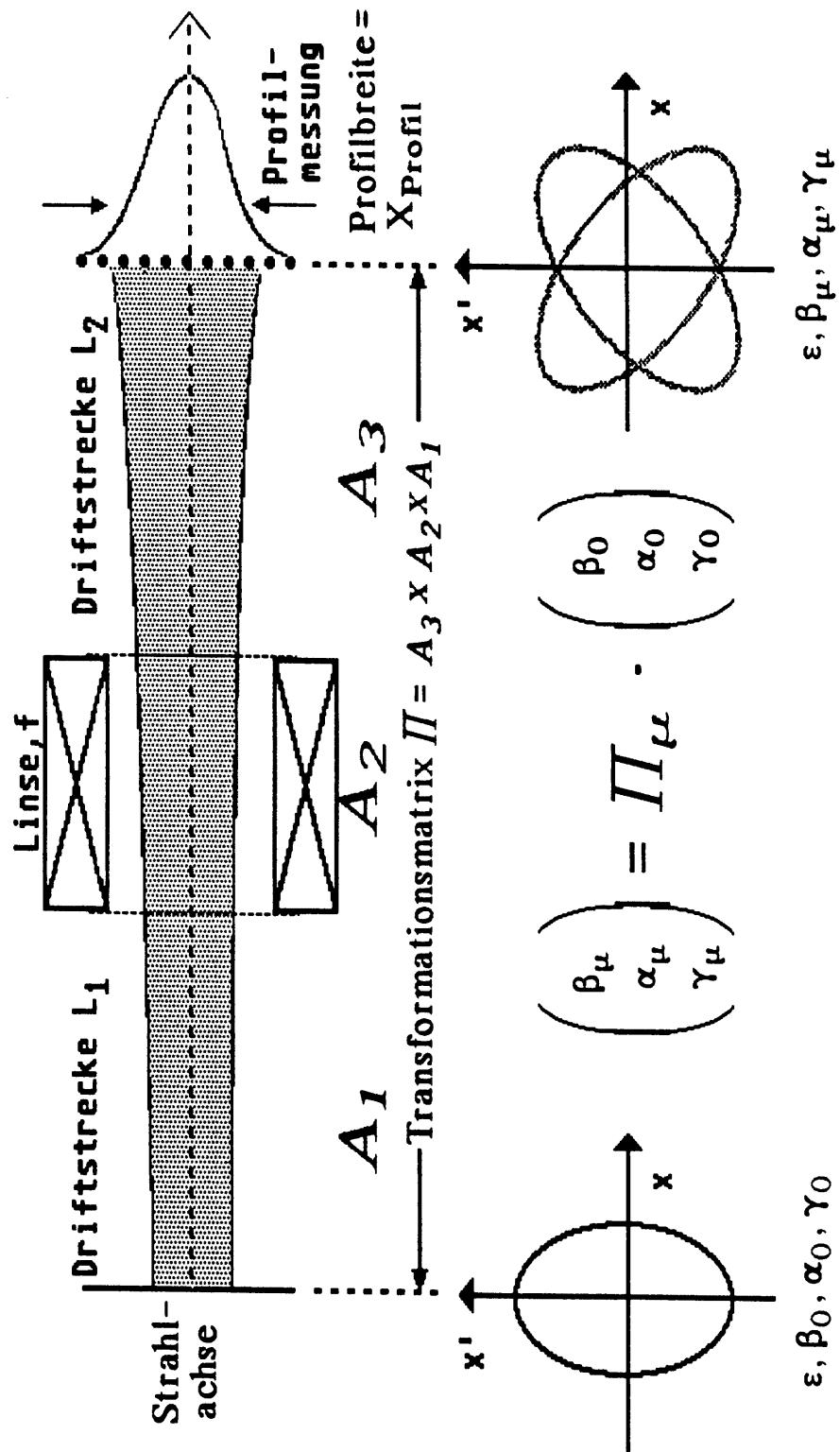


Determination of phase space ellipse from beam profile measurements at 3 places





Determination of phase space ellipse using one lens and profile measurements





Problems :

Power deposition on Slit (& Grid)

Example IFMIF :

100 keV

140 mA

$r < 2 \text{ mm}$

=> Powerdensity > 1 kW/mm²

can destroy measurement device

High voltage breakdowns :

(especially near ion source or electrostatic LEBT)

The grids act like
“antennas” feeding high voltage pulses
into the electronics
(especially for Slit/Grid arrangements)

Secondary particles
can cause :

=> High voltage breakdowns

=> Influence space charge compensation

=> Additional currents on detectors (grid !)

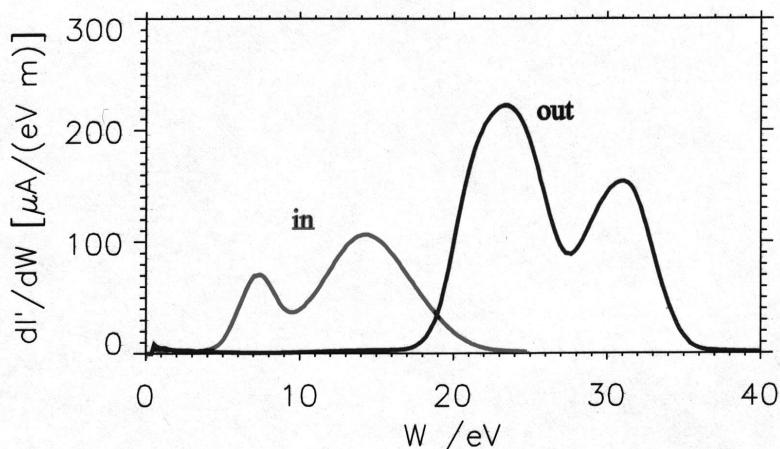
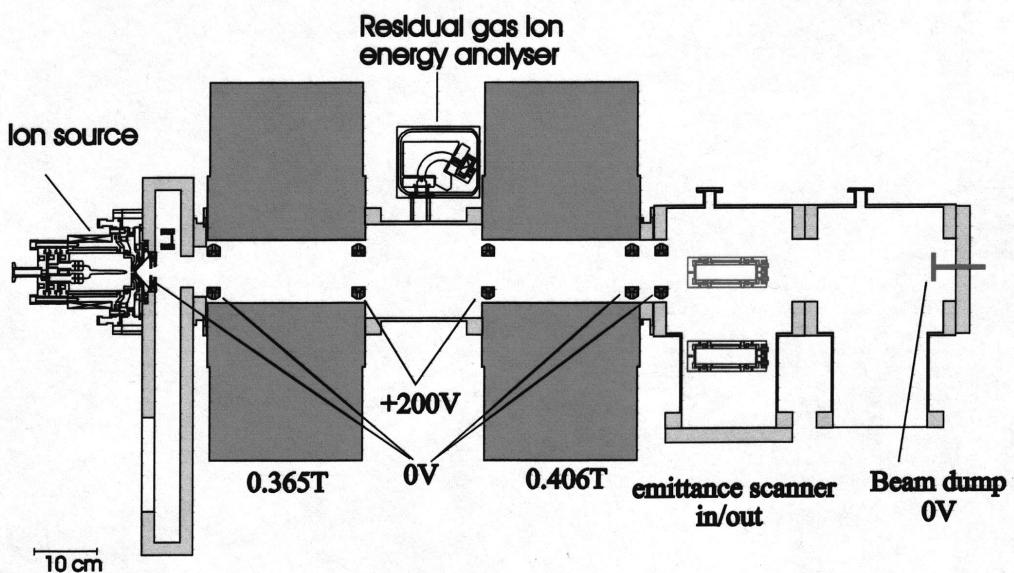


Non destructive Methods Motivation:

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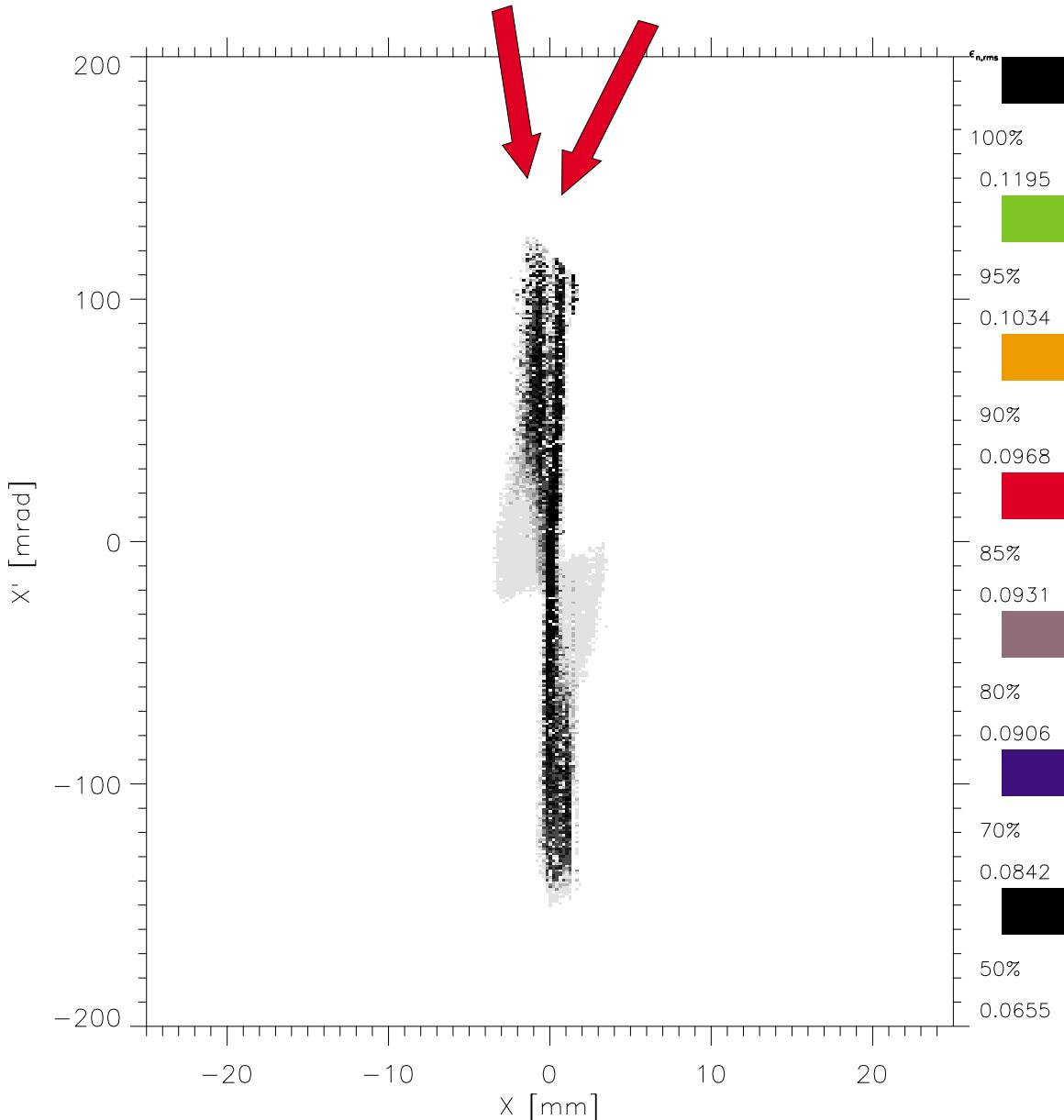
Interaction between the ion beam and the measurement device can produce secondary particles and therefrom influence the space charge compensation and change the emittance of the ion beam.

Example :
 He^+ , 10 keV , 3 mA



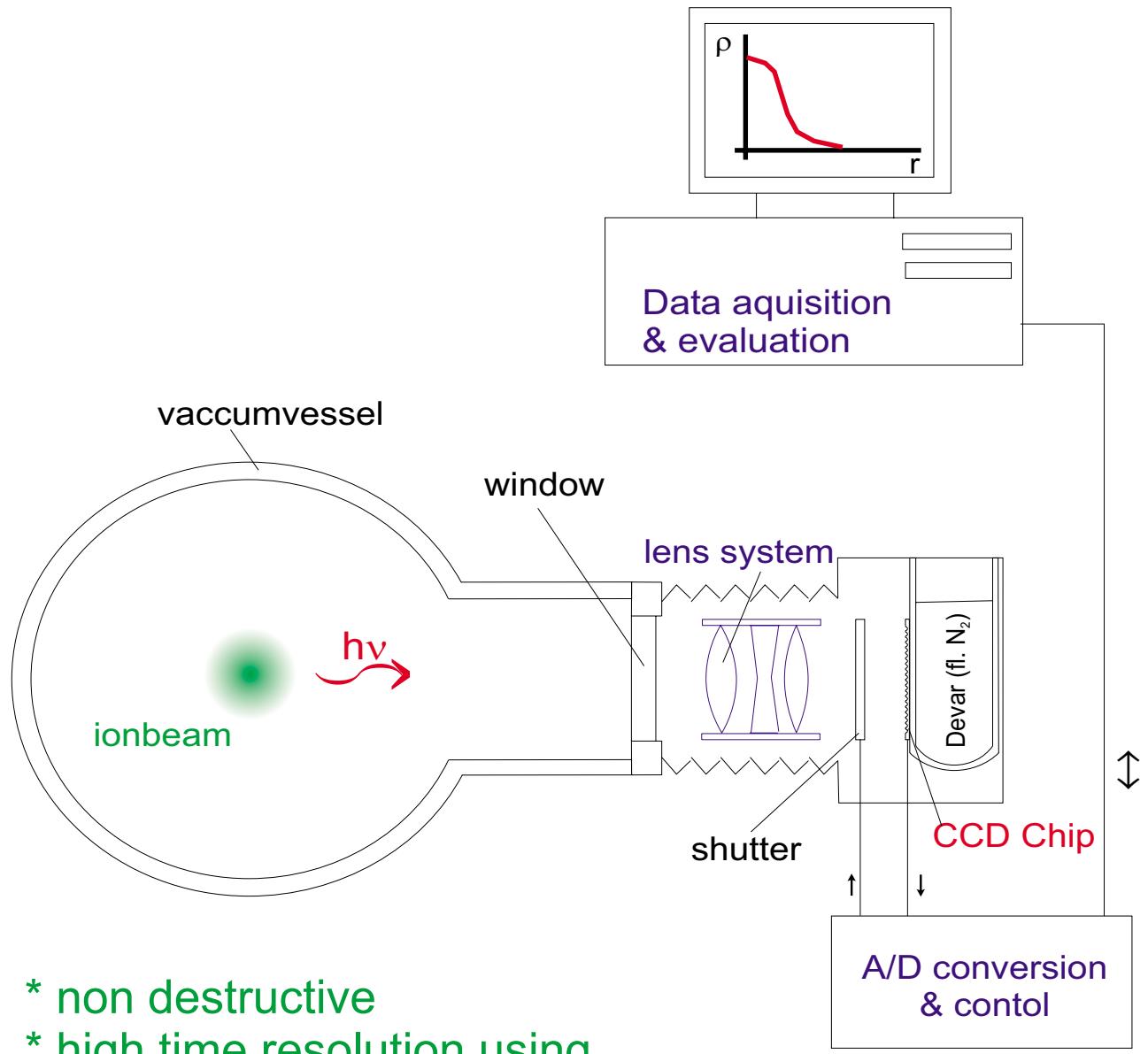
Production of noise and bistable states by disturbance of the beam transport

Example :
Measurement at Gabor lens LEBT
 Electrons produced by the interaction between
 Allison scanner and beam ions
 influence space charge cloud of the lens.
 Two semistable conditions occure.
 The revolution frequency was some Hz.



CCD-Camera

Highly efficient spatial resolved electron production by the inner photo effect detecting the incident light emitted by interaction between beam ions and residual gas atoms.



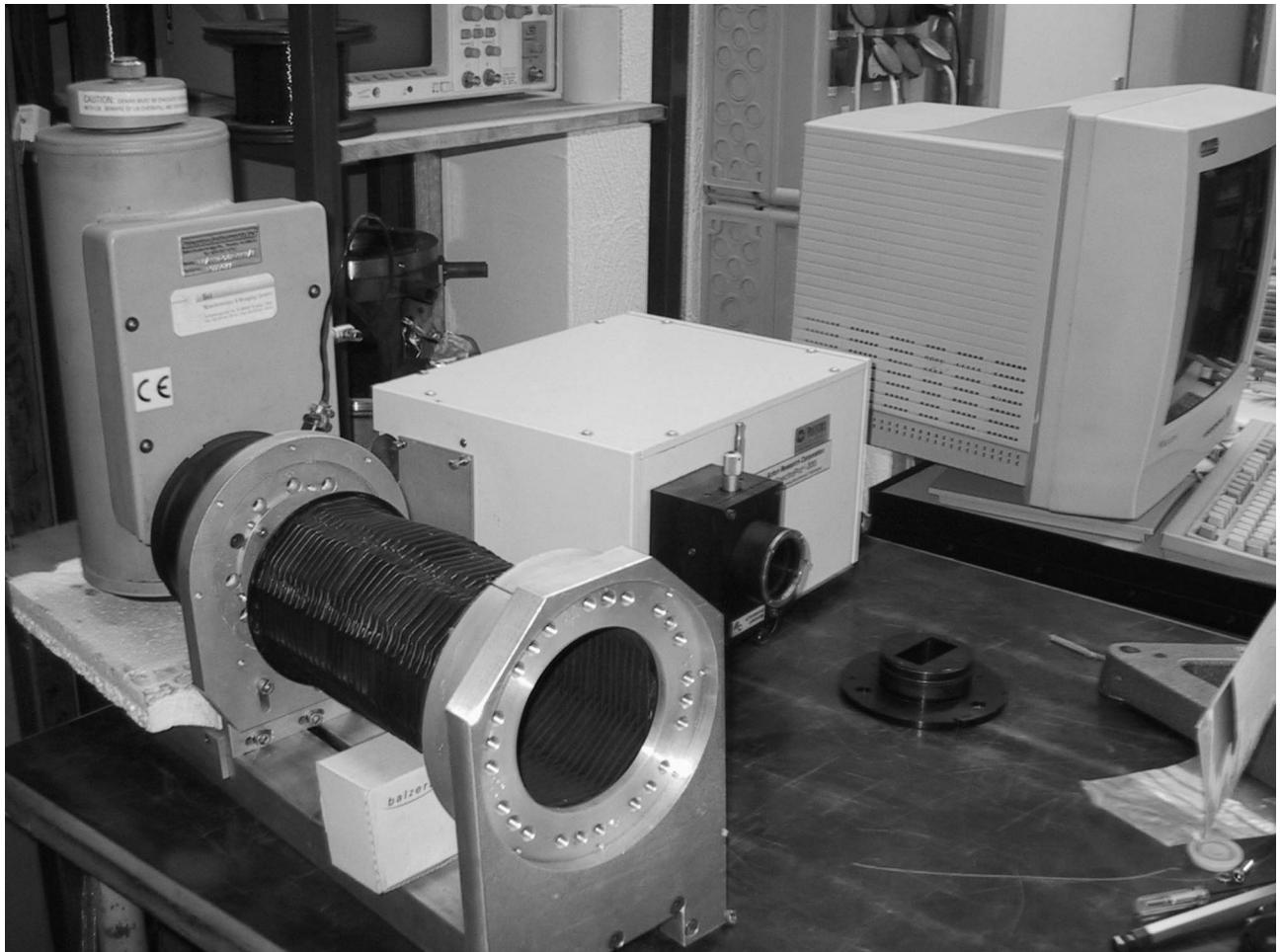
- * non destructive
- * high time resolution using gated residual light amplifiers(>50 ns)



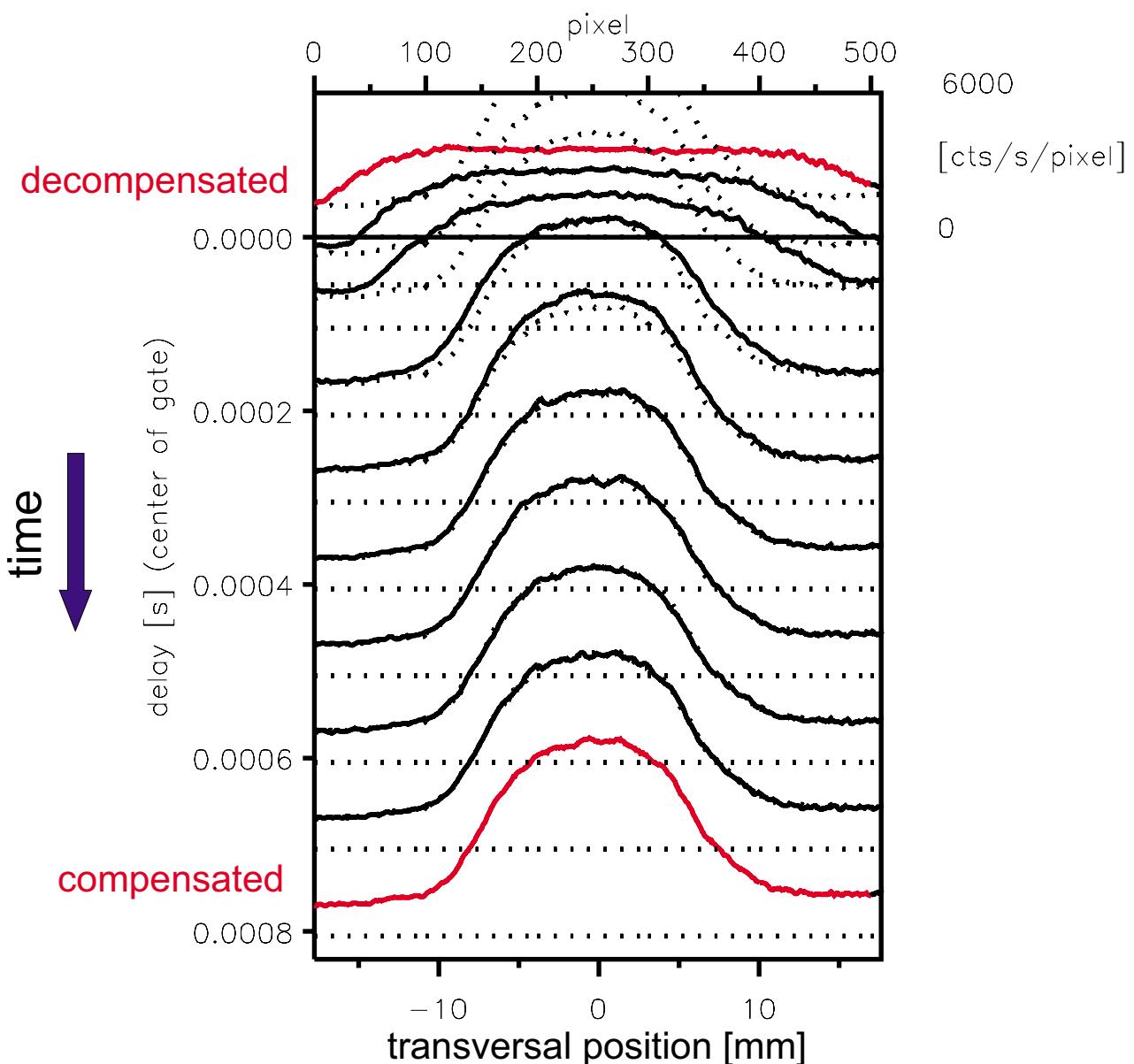
CCD camera

and

optical spectrometer



Time resolved
CCD camera measurements
to determine non destructive
the rise time of space charge compensation

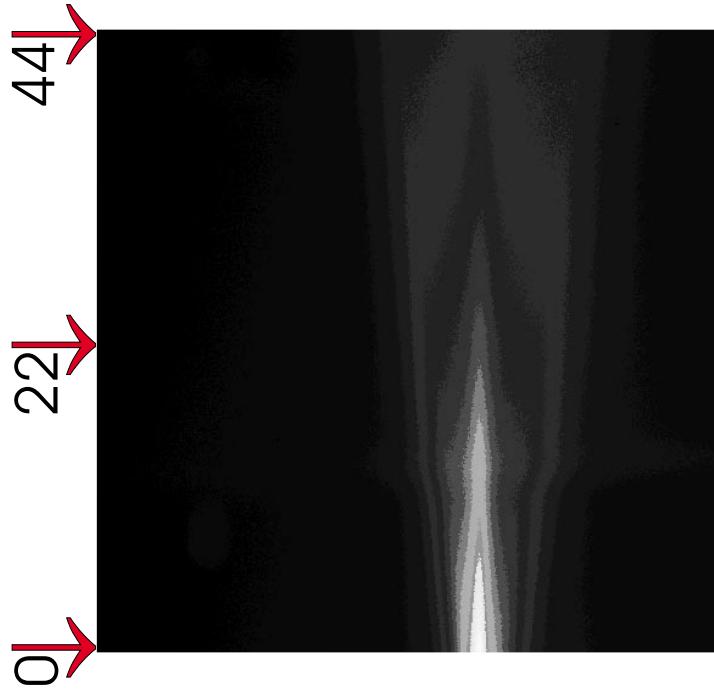


high spatial (0.1 mm) and
temporal (50 ns) resolution.



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CCD image - multiple profile measurements



Counts

2000
1500
1000
500
0

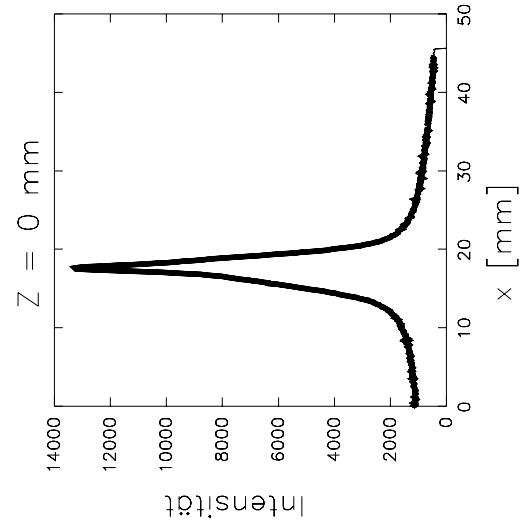
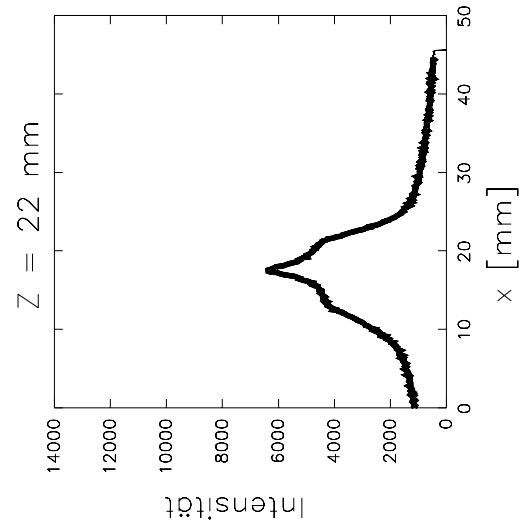
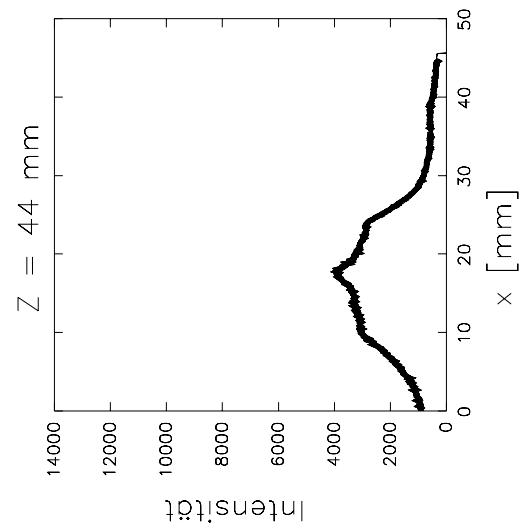
500

0

-500
-1000
-1500
-2000
-2500

Profile x

Red arrows pointing to the profiles in the image.





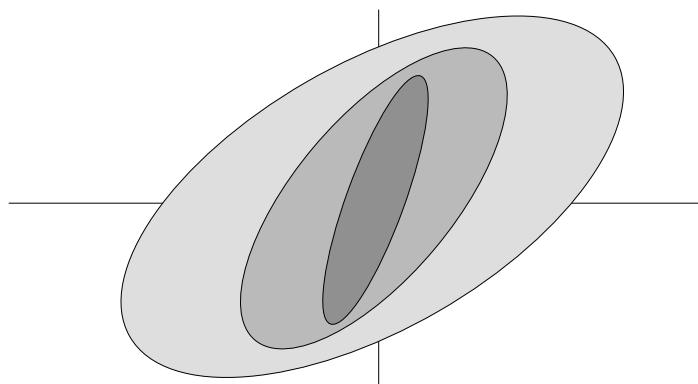
Determination of beam emittance by use of CCD camera measurements

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“A single CCD image has all necessary information to determine the emittance using the 3 profile method”

Advantages :

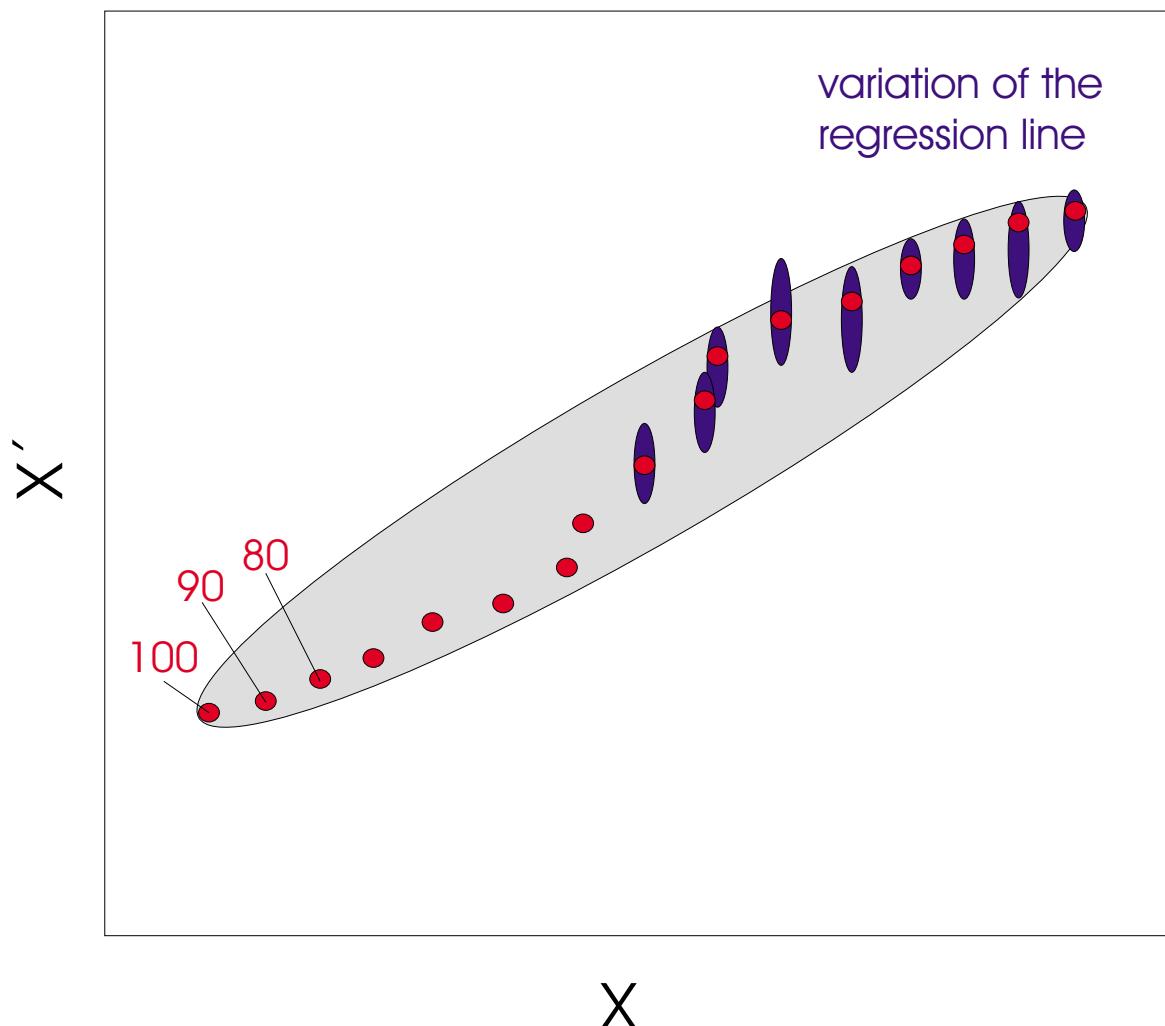
- a) easy setup
- b) high signal to noise ratio allows use of radial intensity profile information
(determination for different intensity fractions 10, 20, 30...%)



$$E(\langle x \rangle, \langle x' \rangle) = k(I(x, z))$$

- c) the set of equation is overdetermined
(3 profils necessary, 512 profils available)
=> can be used to gain additional informations
(space charge !)

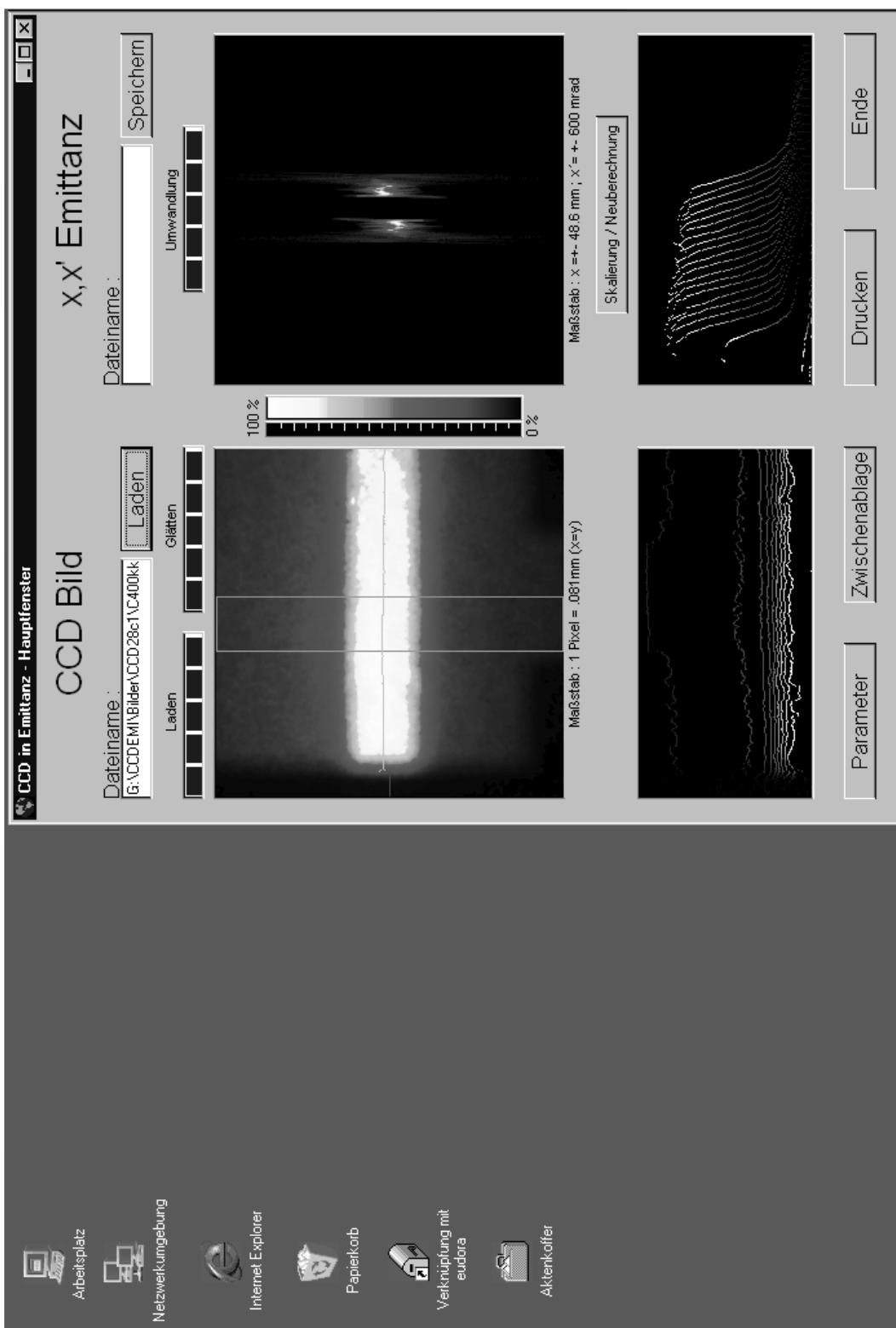
Variing the **fraction of beam current** taken into account and using the **over determination** of the system the emittance ellipse can be filled





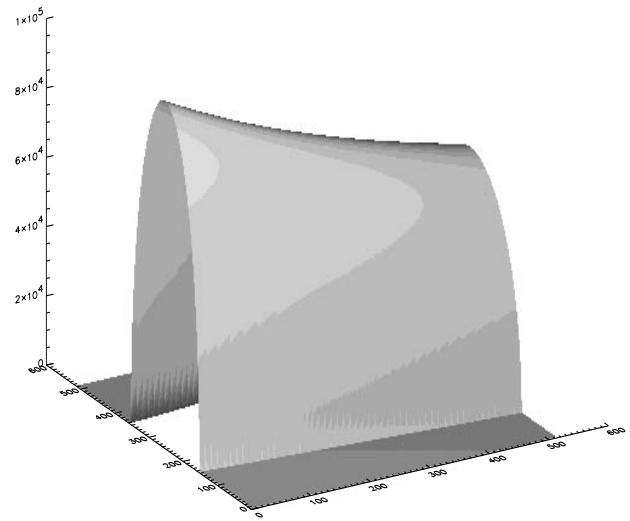
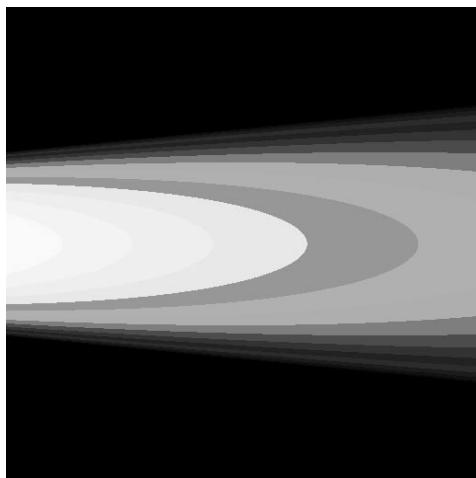
A Windows program code has been developed to determine beam "emittance" from CCD images

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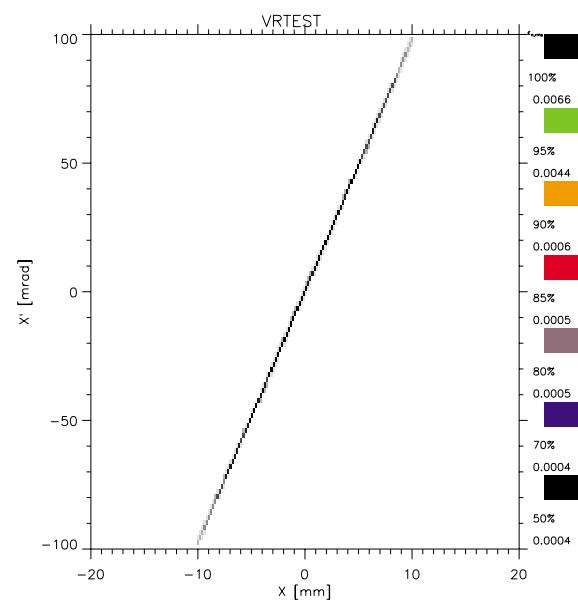
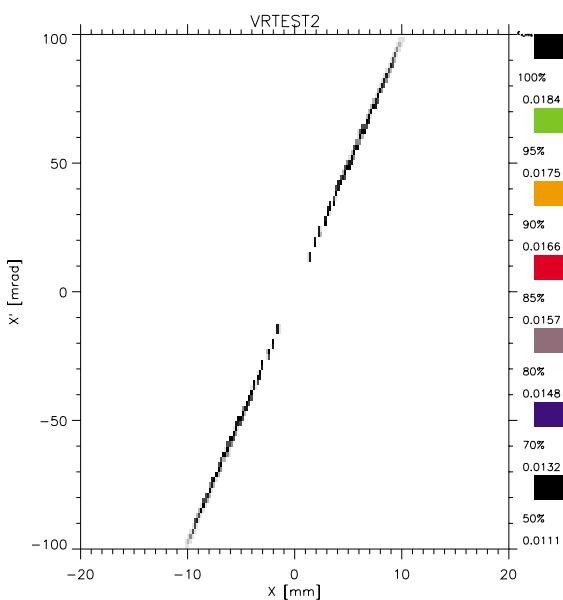


Example

Use of numerical simulated CCD image (laminar beam)

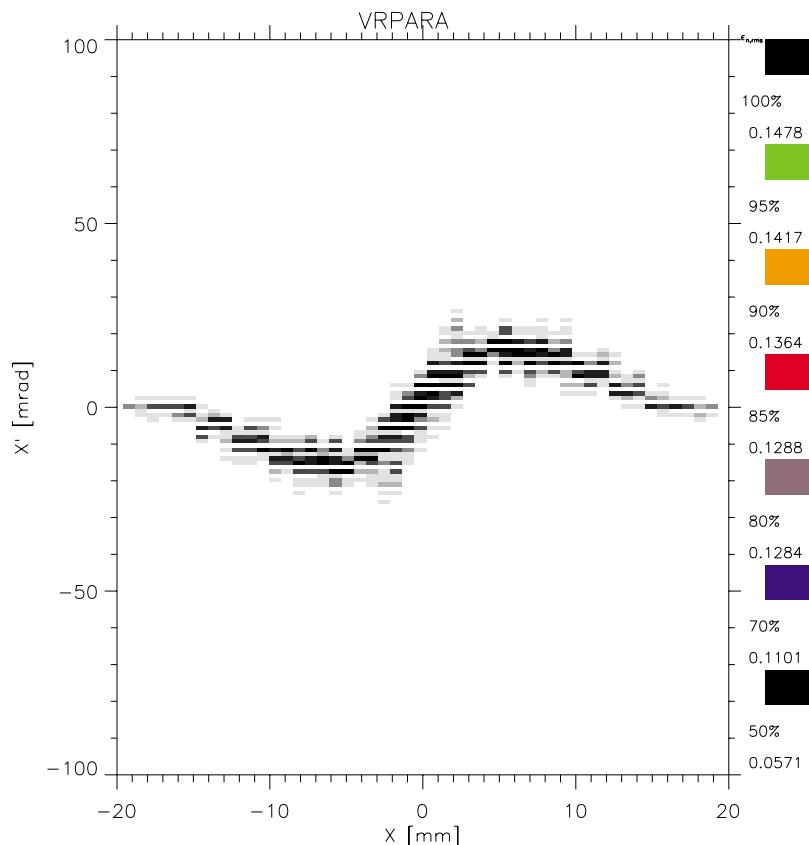
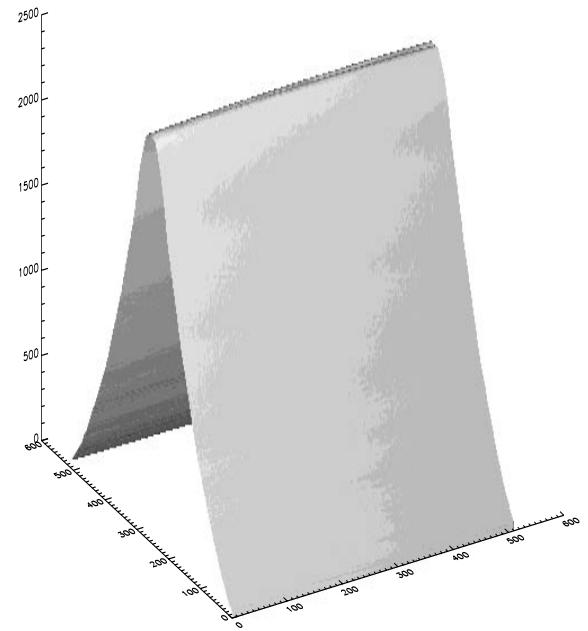
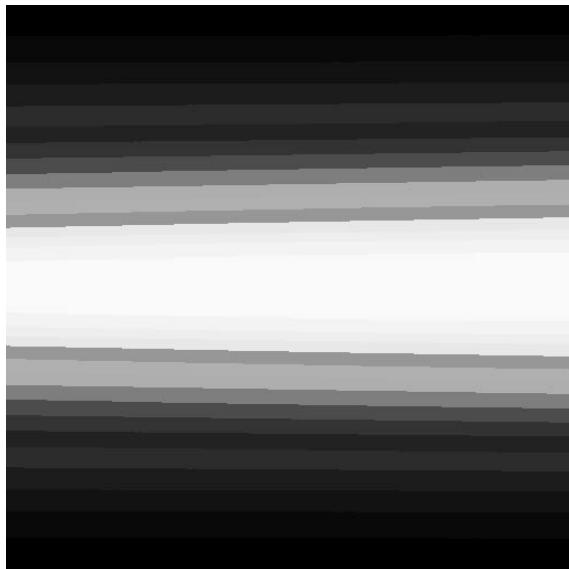


without
with
Interpolation



Example 2

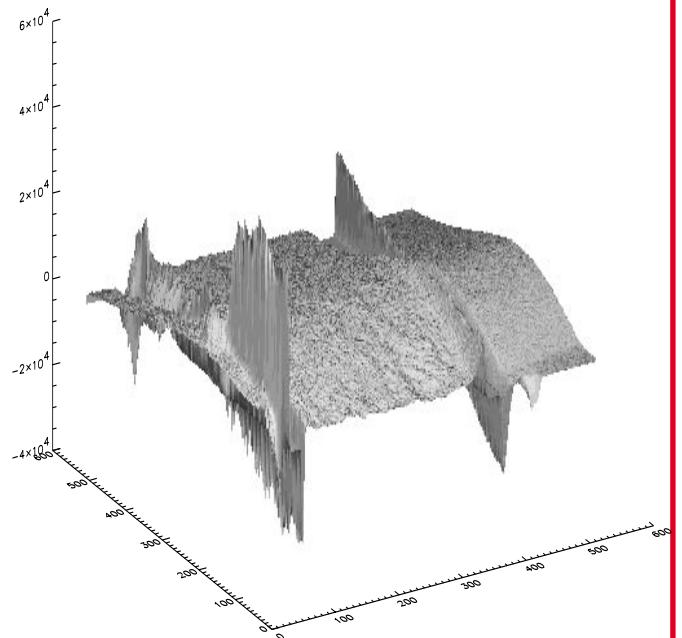
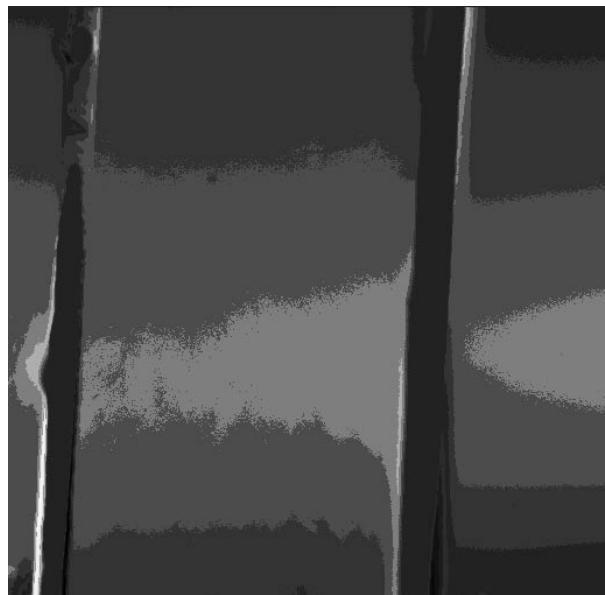
Use of numerical simulated CCD image (using measured emittance of real beam)



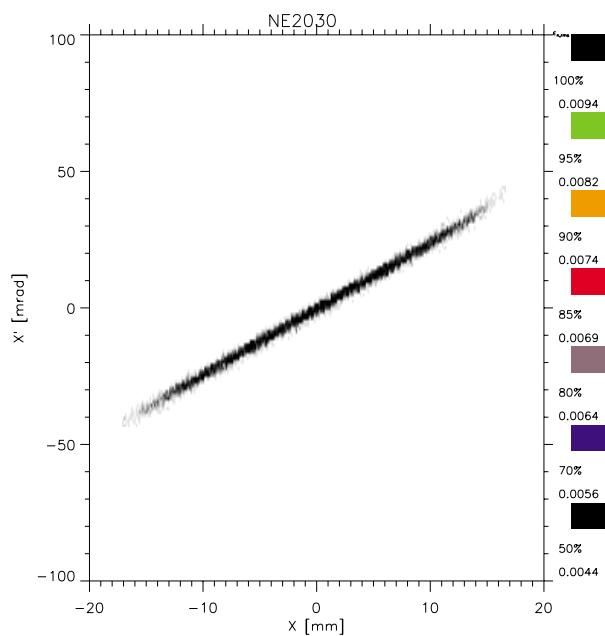
Example 3

Use of measured CCD image (Ne+, 8 keV, 1 mA)

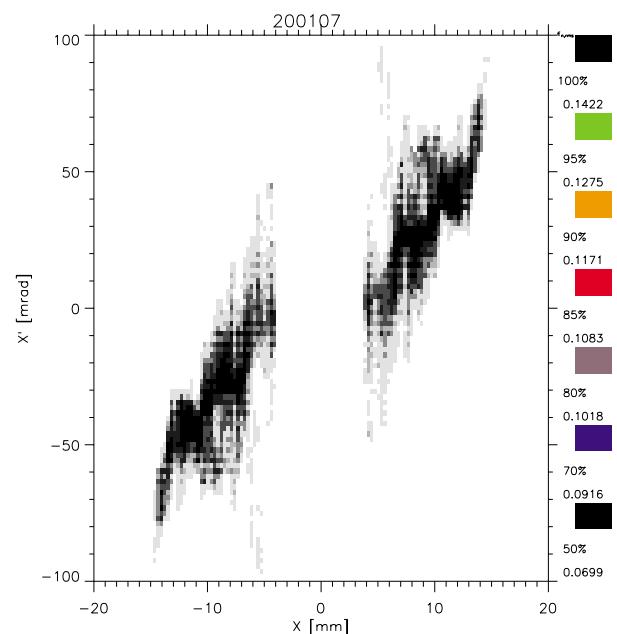
and comparison with classically measured emittance.
 Influence of noise and reflections on transformation.



measurement



from CCD

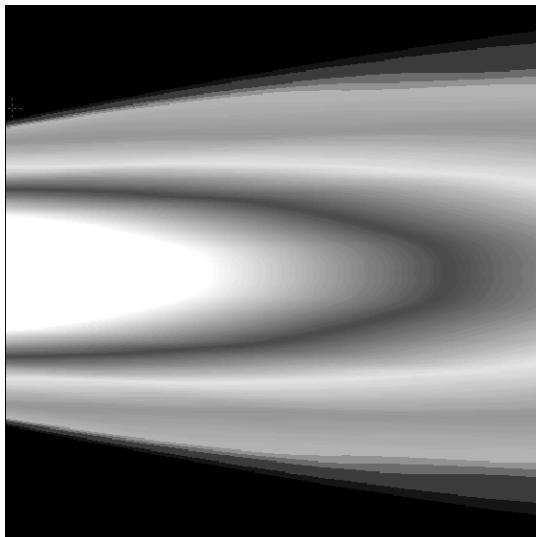




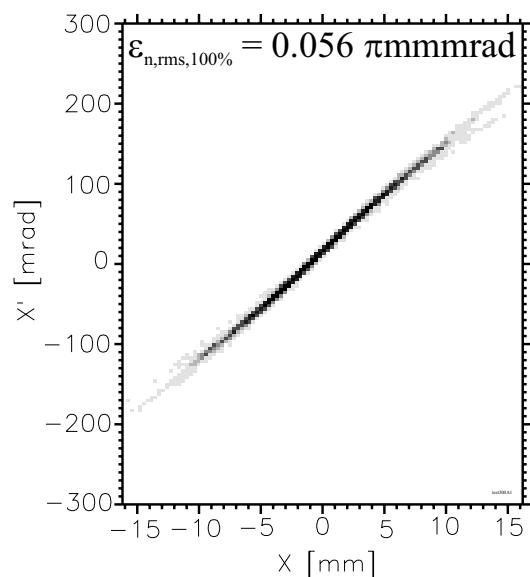
Example 4

Use of measured "high quality" CCD image (He⁺, 10 keV , 5 mA)

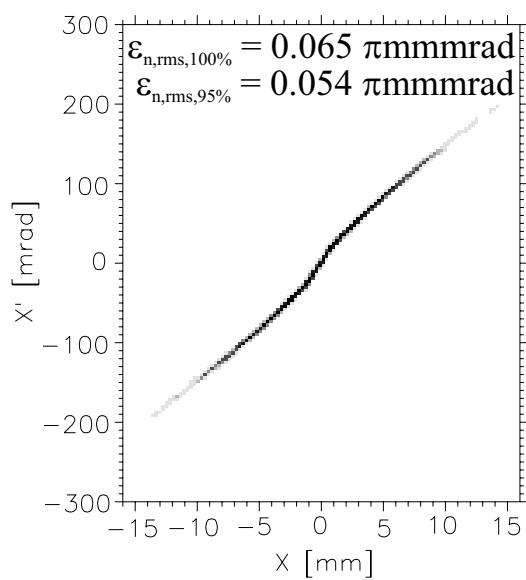
CCD-image



Emittance

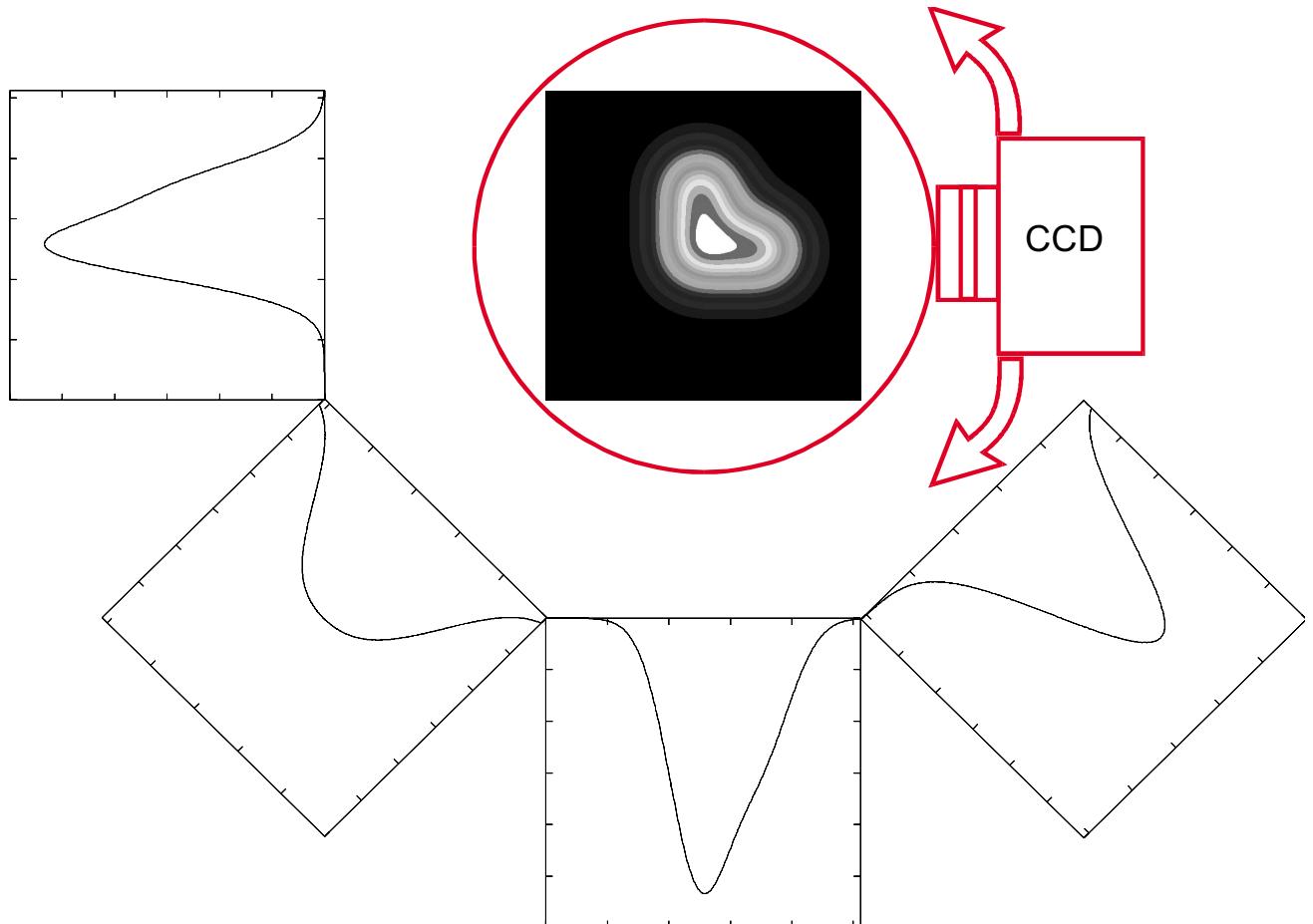


Emittance determined by use of CCD image





CCD - tomography for determination of non symmetric particle distributions



By use of an sufficient number of profile images of the ion beam the transversal density distribution of the ion beam can be unequivocal determined.



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CCD - tomography for determination of non symmetric particle distributions

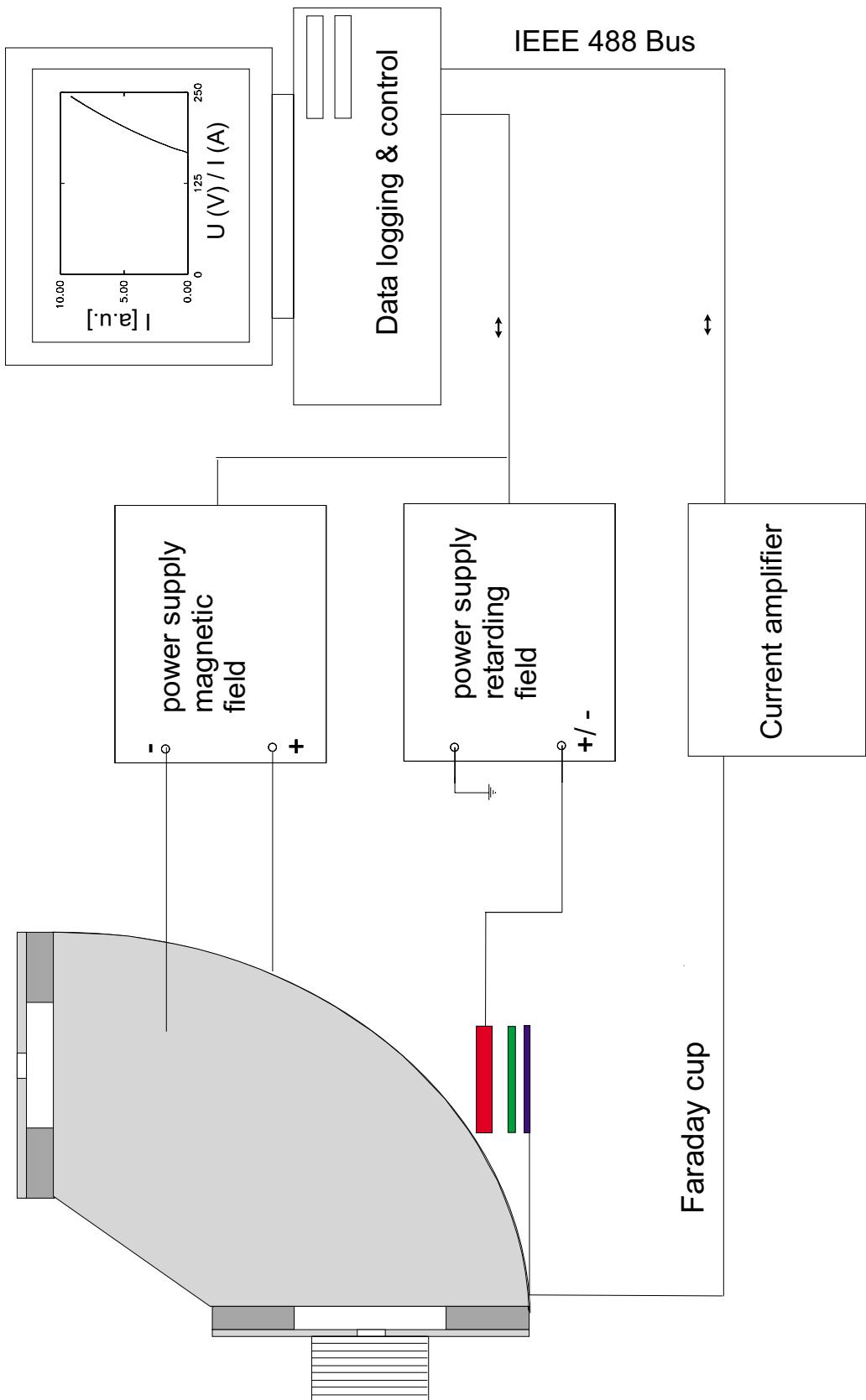
Set up of plexiglass cylinder



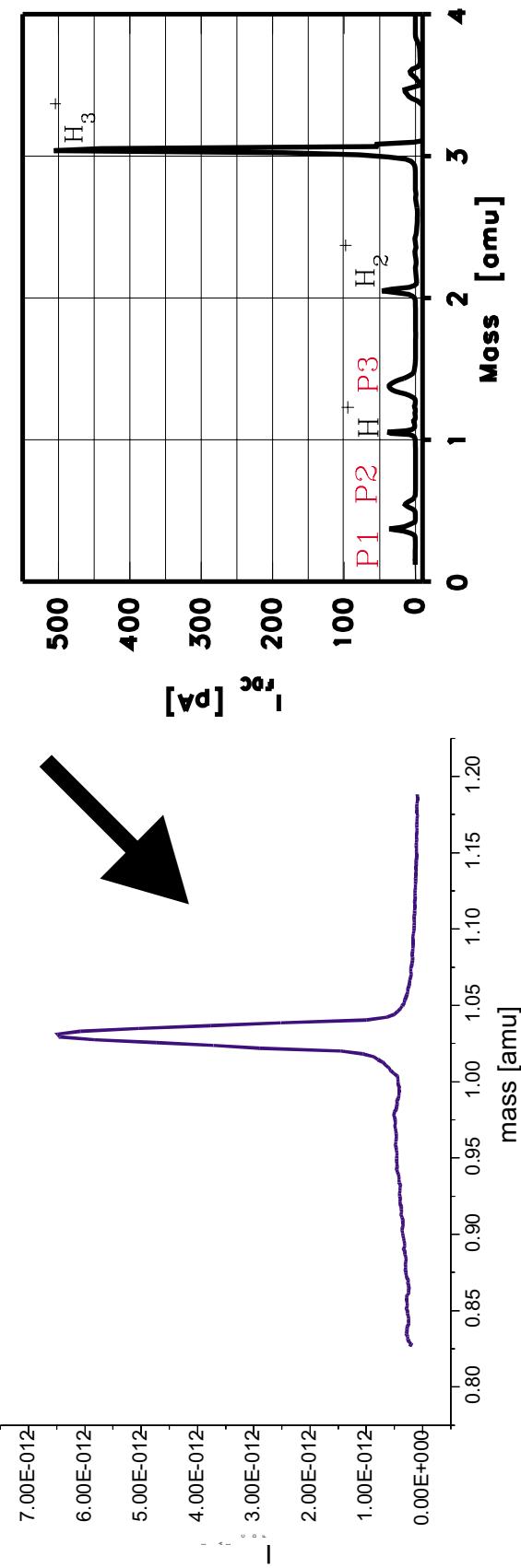
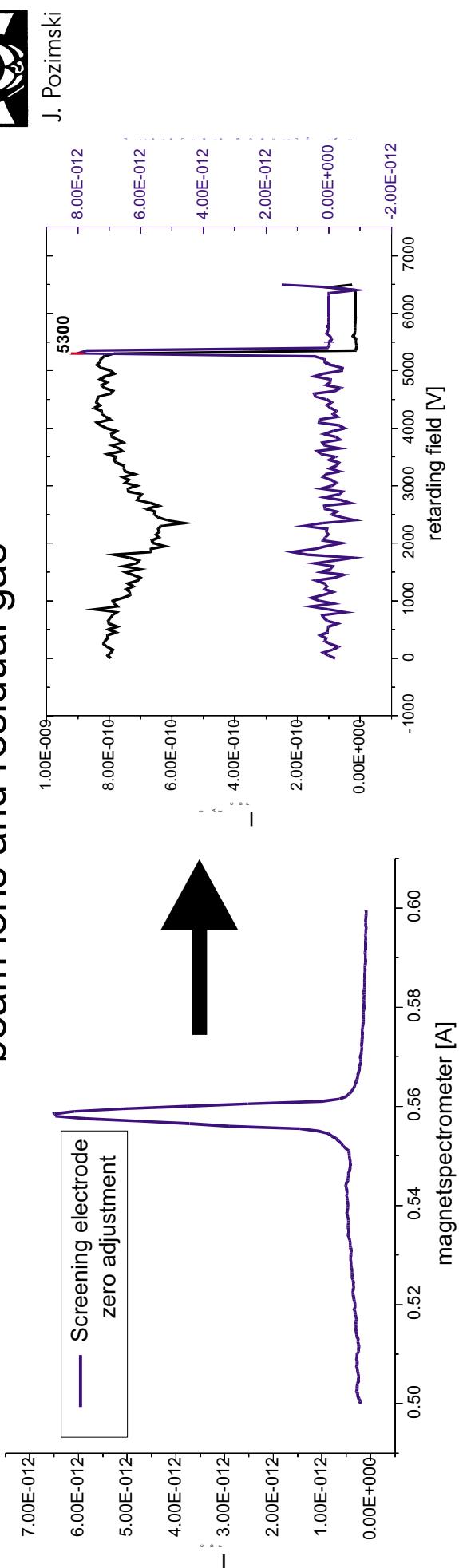
Preexperiments to test the
optical and vacuum technical
properties of certain materials
to build a transparent cylindrical
"vacuum window"

Magnetic dipole and electrostatic retarding field spectrometer to determine simultaneously mass and energy of charged particles

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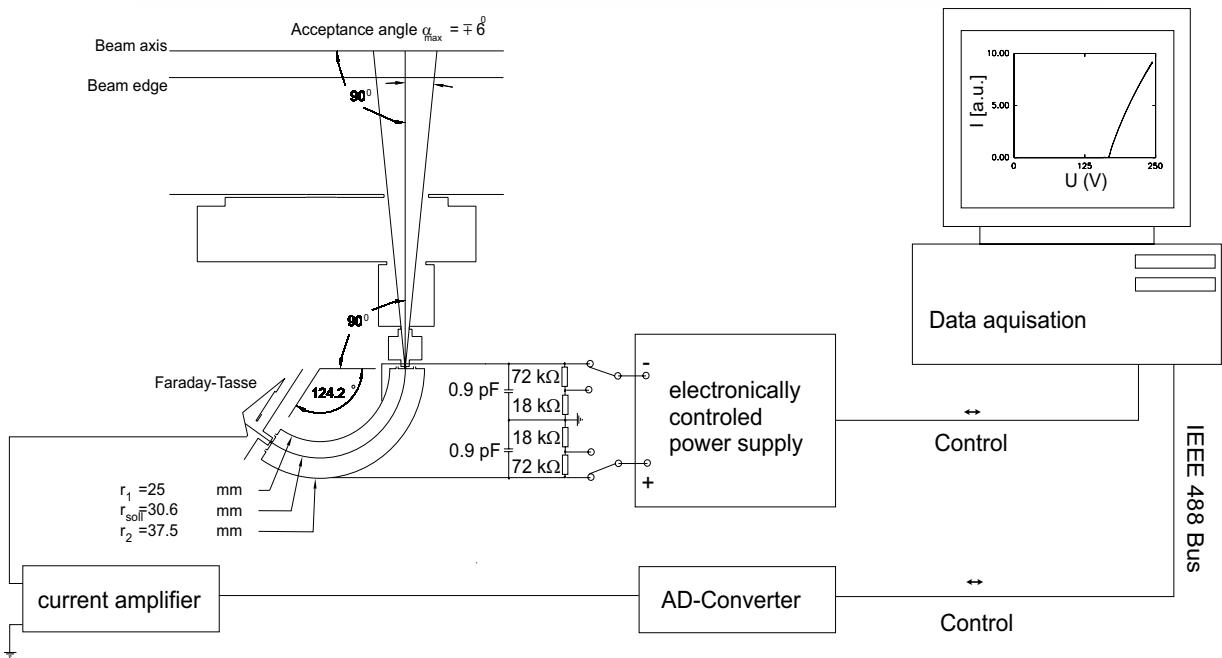
Determination of Mass and energy of secondary particles produced by interaction between beam ions and residual gas



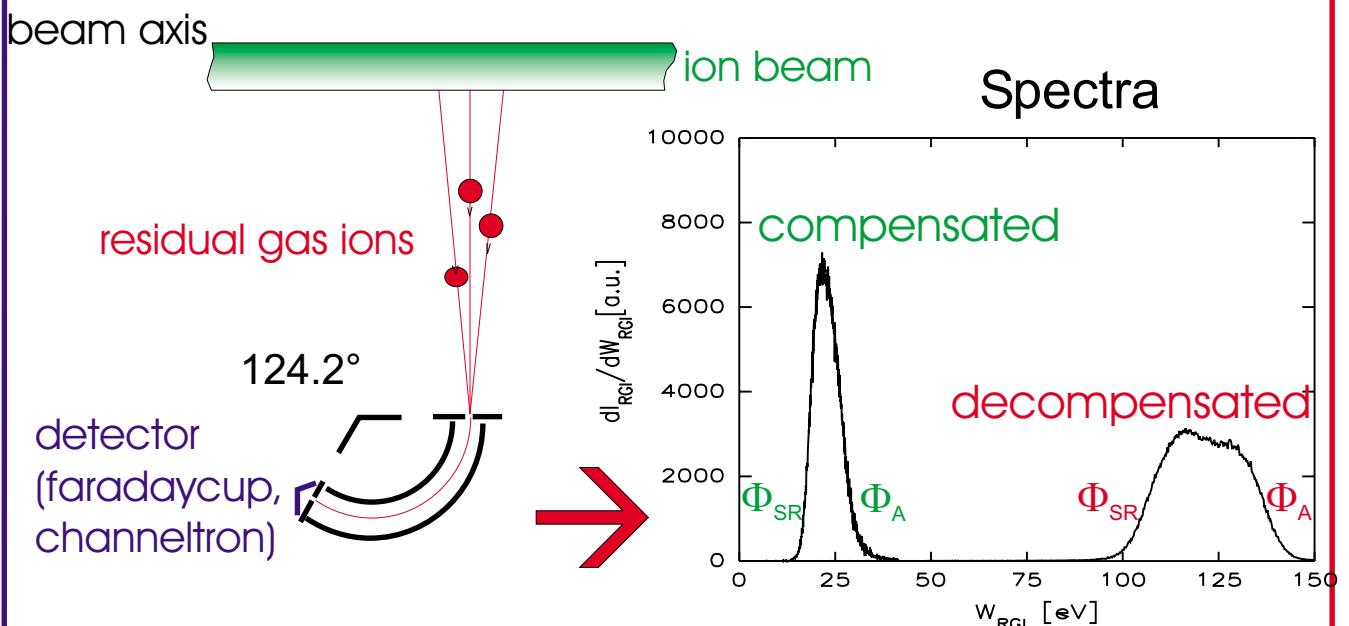


Residual ion energy spectroscopy for non destructive potential measurements using an electrostatic analyser of the Hugh-Rojanski type

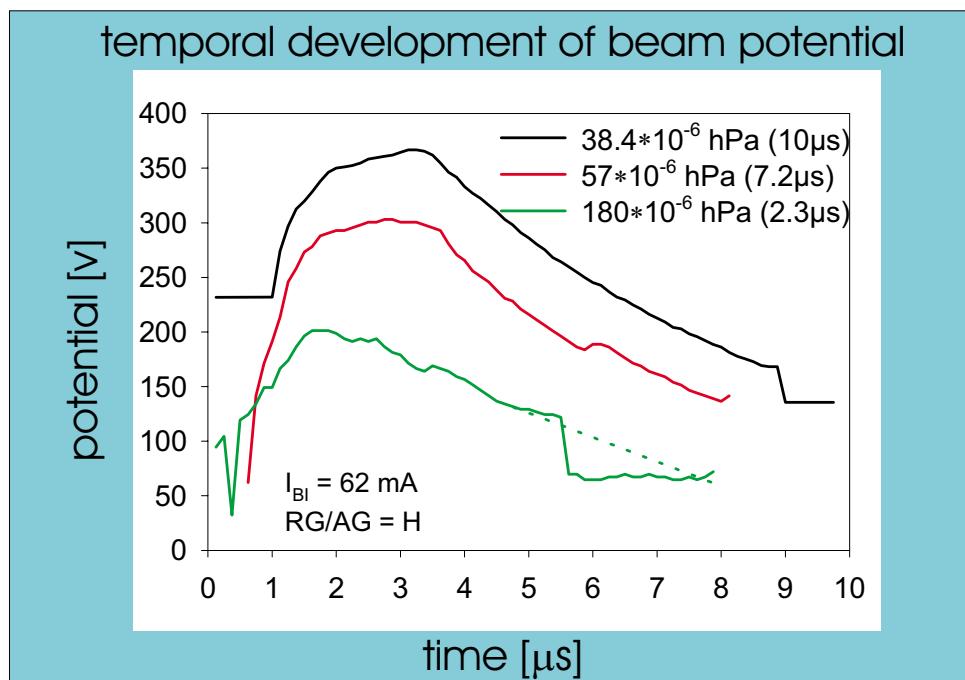
Spectrometer No. 1 -Faradycup



Residual ion energy spectroscopy for non destructive potential measurements using an electrostatic analyser of the Hugh-Rojanski type



Measurements at the SILHI-LEBT at CEA-Saclay
 H^+ ; 92keV ; 62mA ; $P_{RG} = 57 \cdot 10^{-4}$ Pa ; $\tau_{min,100\%} = 7.2 \mu s$



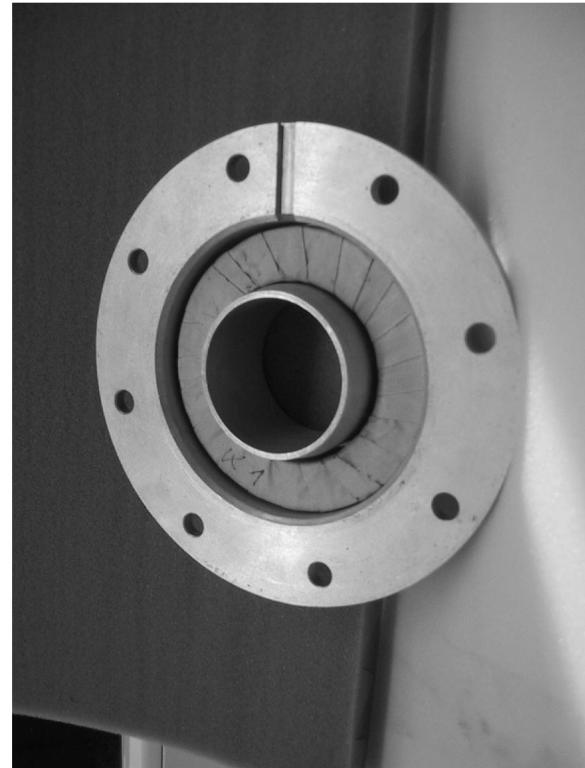


Other diagnostics

Faraday cup



Current transformer



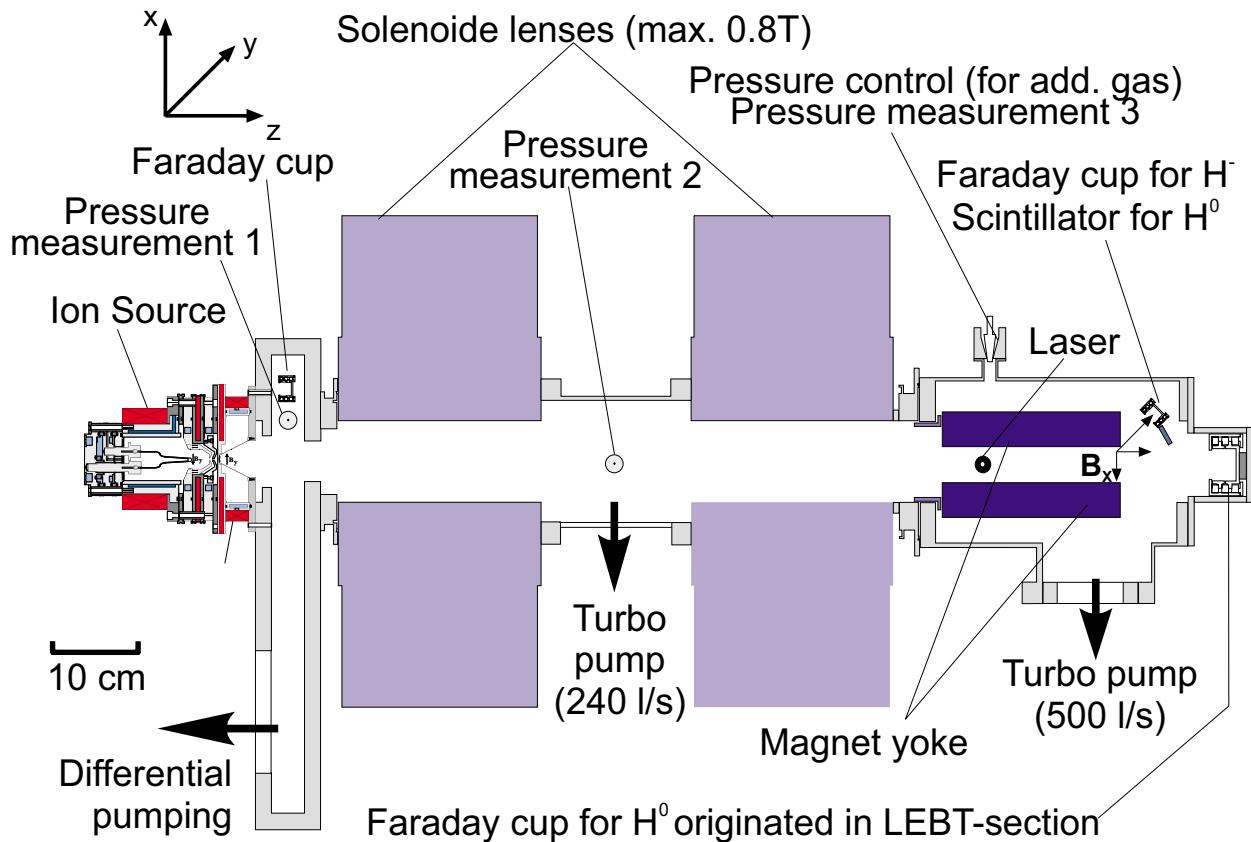
- * Langmuir probes
- * RF - probes
- * Electron beam probe
- * Pickups



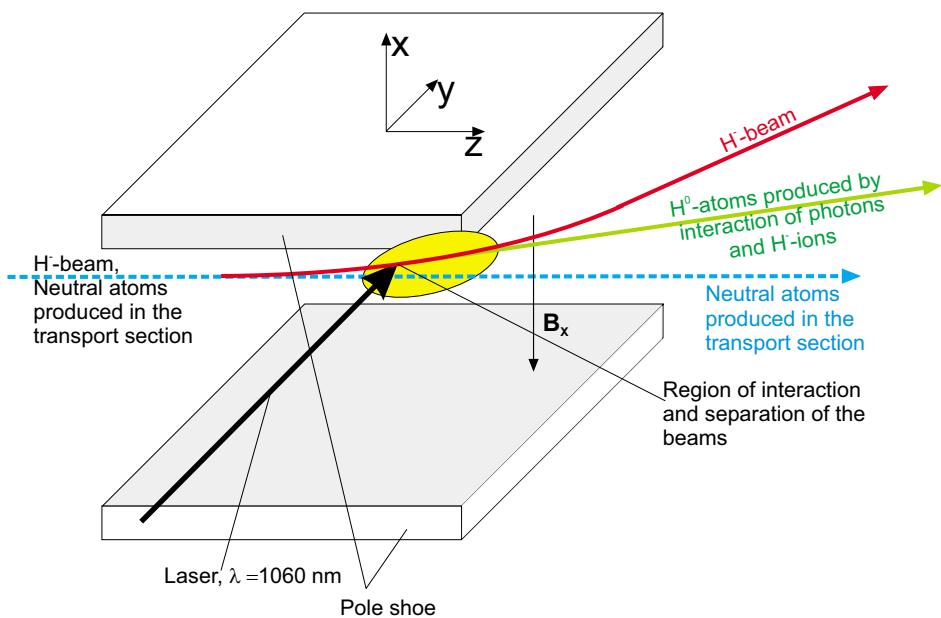
Laser neutralized emittance measurement (C. Gabor)

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Experimental setup



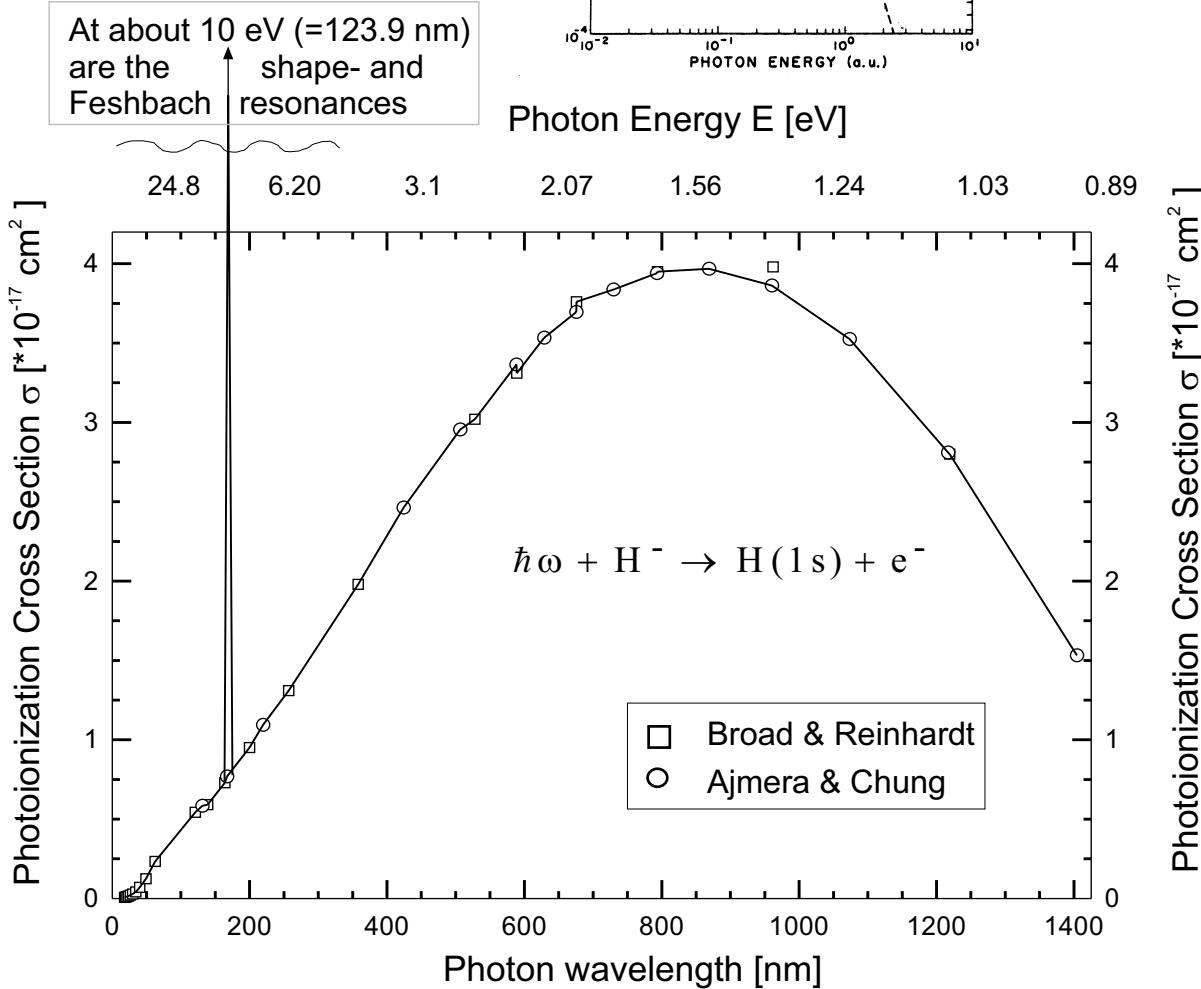
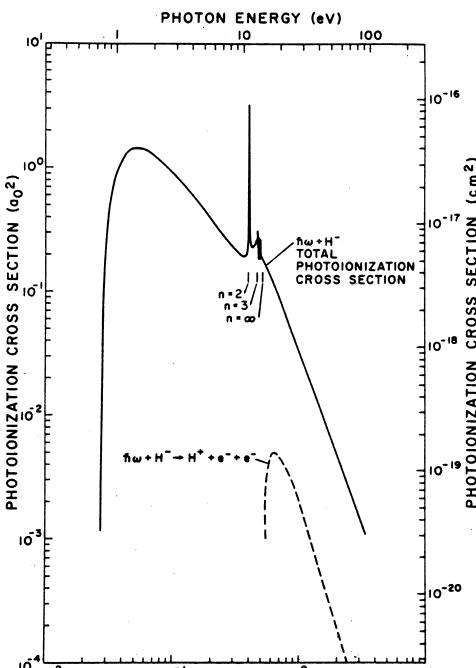
Principle of a laserinduced emittance measurement for H⁻-beams





Photoneutralization

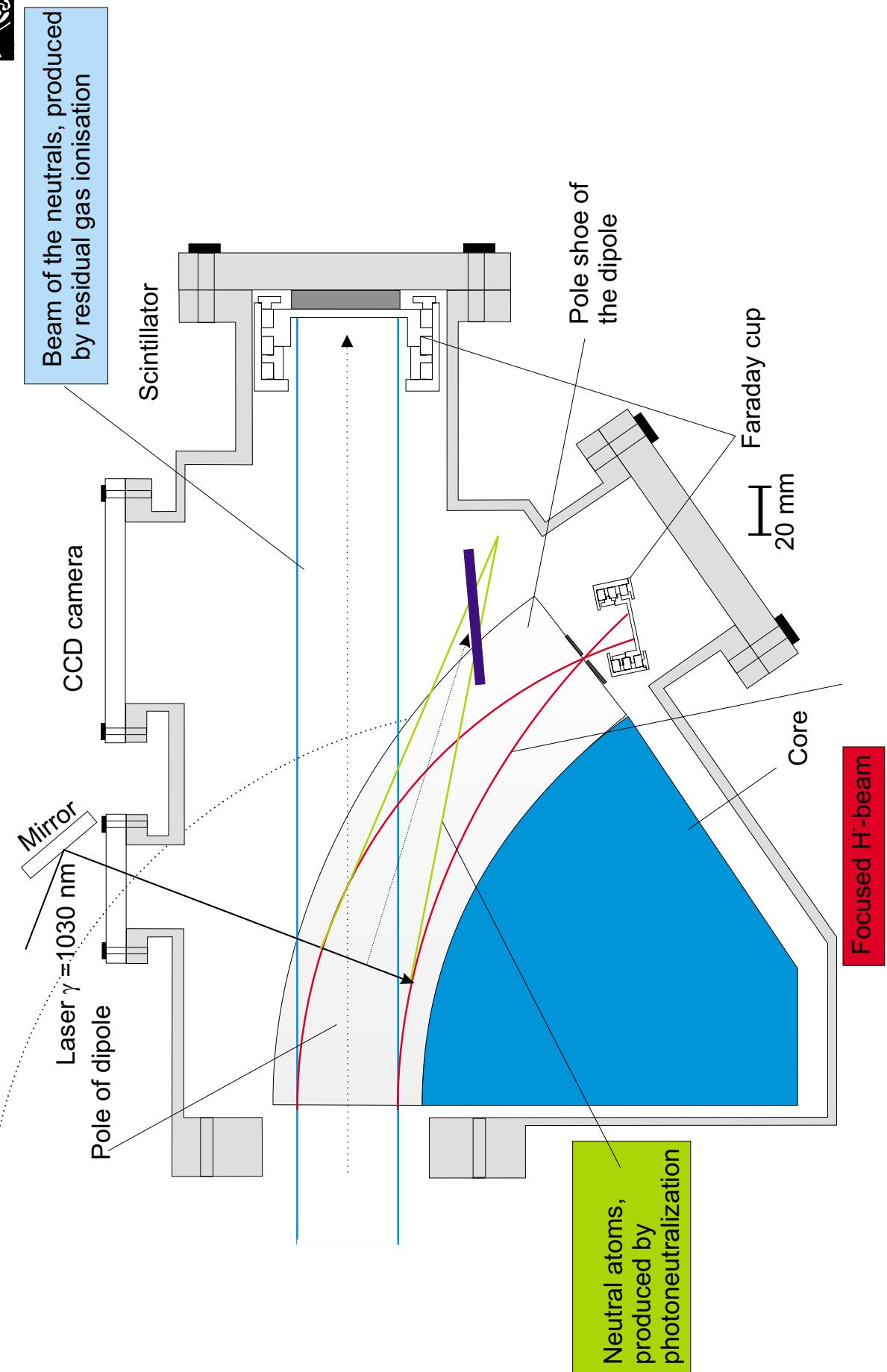
a_0^2 is a special unit in the theoretical atomic physics



- [1] J. T. Broad and W. P. Reinhardt, „One and Two Electron Photojection from H^- Atoms“, Phys. Rev. A14, 1976
- [2] M. P. Ajmera and K. T. Chung, „Photodetachment of Negative Hydrogen Ions“, Phys. Rev. A12, 1979



Experimental setup of diagnostic chamber and dipole

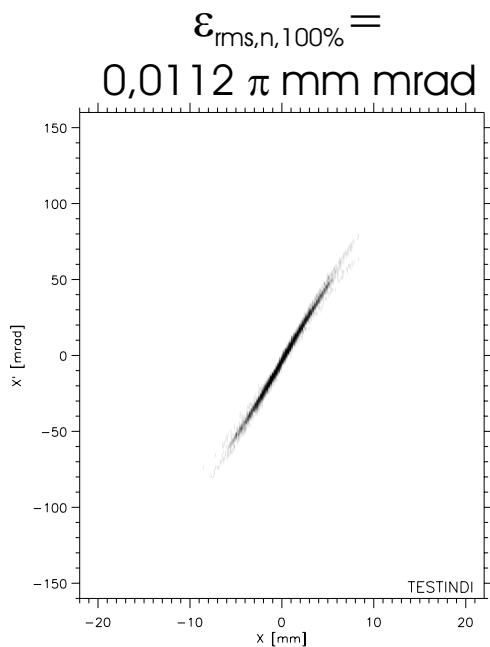
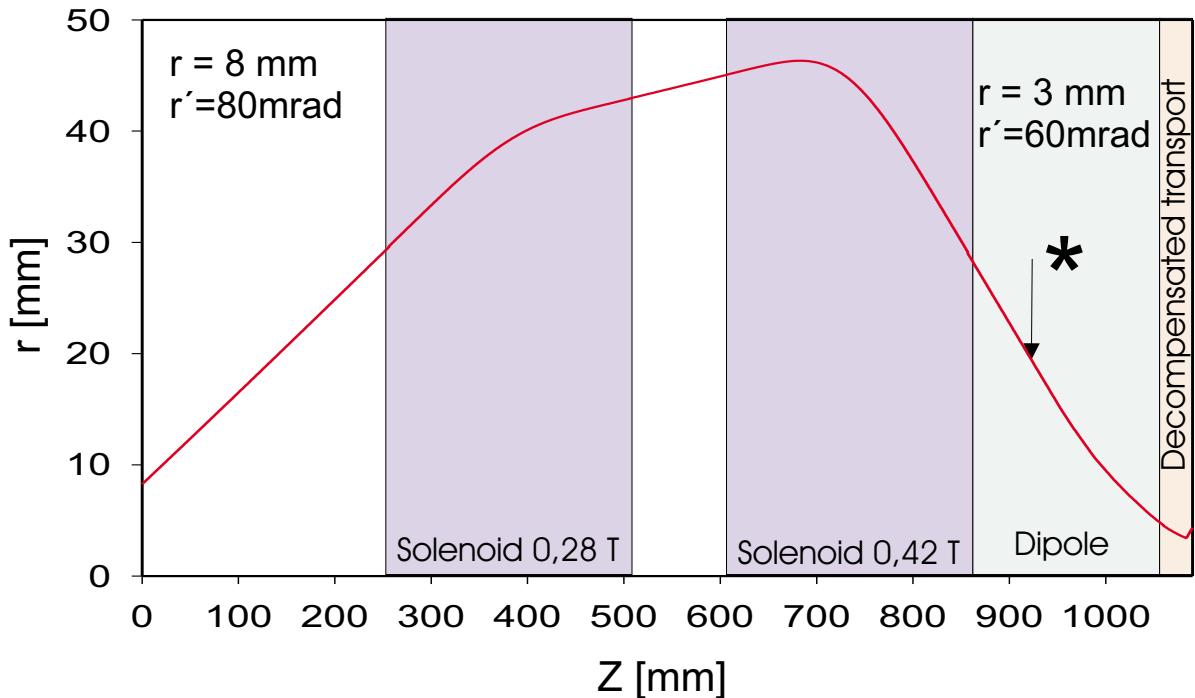




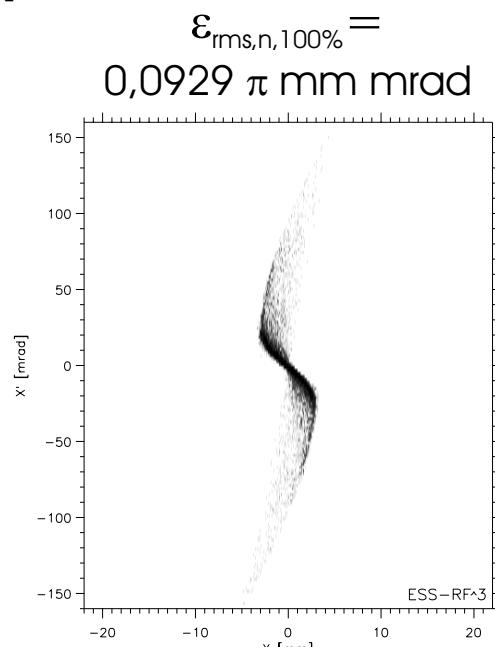
Numerical calculation of beam transport

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Beam envelope of 55kV, 70mA, H⁻-beam



Initial (calculated)



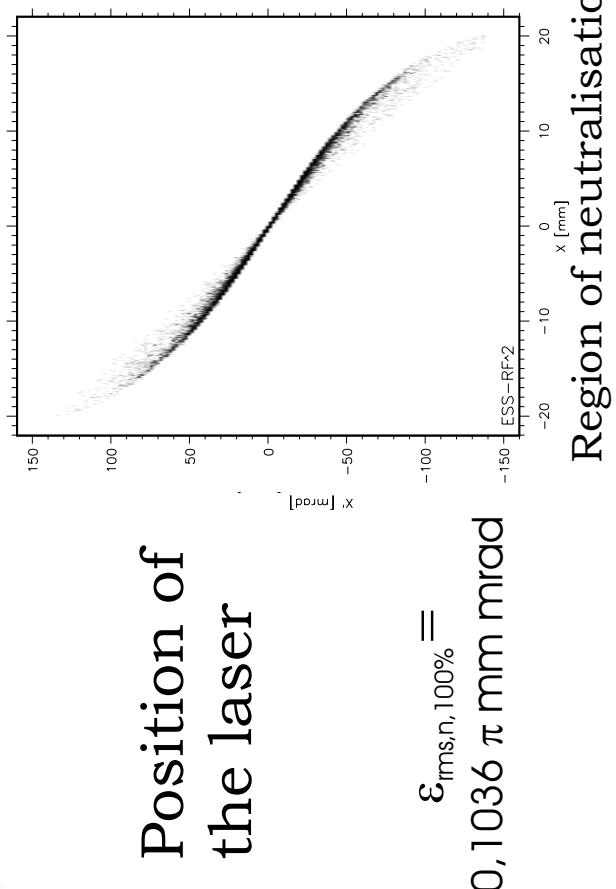
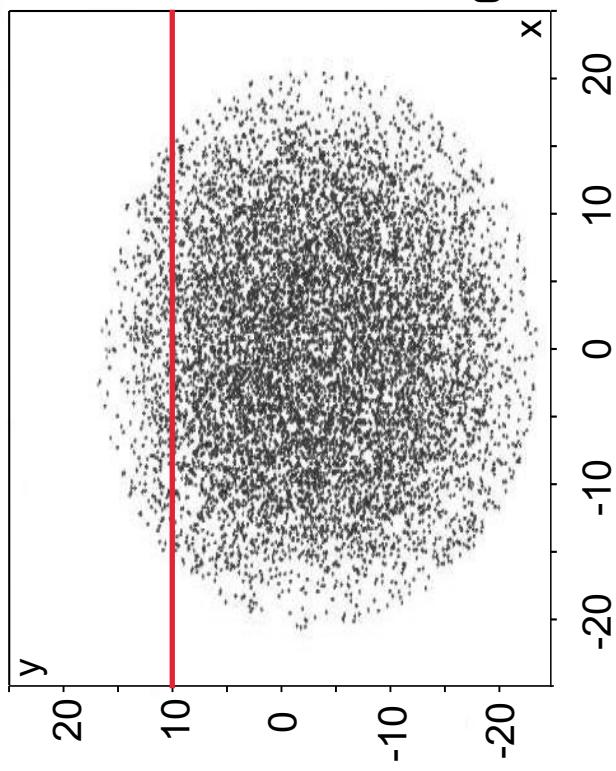
Entrance of RFQ

- * In this plane the laser scans transversely through the ion beam. That is app. after the first third in the magnet field.

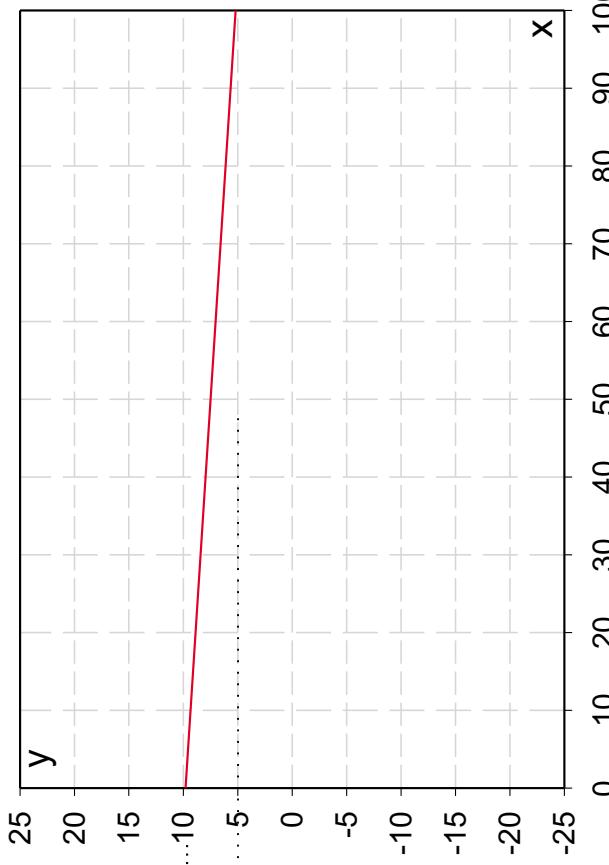
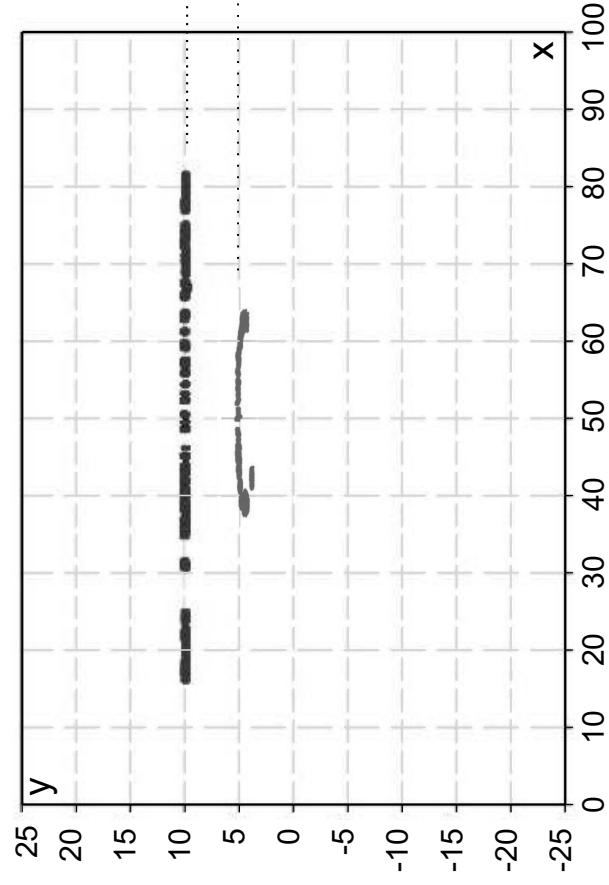


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Simulation of interaction between laserbeam and H⁻-beam



Region of neutralisation





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Summary

Beam diagnostics is
an important subject
for design, optimisation
and operation
of an Low Energy Beam Transport section

- * Destructive methods like
 - Faraday cups
 - Emittance scanner

....

are well known but suffer
from high power density and their
influence on beam transport

- * non destructive methods like
 - RGI -spectroscopy
 - CCD - imaging
 - laser neutralisation

....

do not desturb beam transport
but some applications
are still subject of
investigation themself.